

**TITLE OF THE INVENTION:**

**AN IMAGE RECORDING DEVICE AND AN IMAGE RECORDING  
SYSTEM**

**5 BACKGROUND OF THE INVENTION:**

**(Field of the Invention)**

The present invention relates to an image  
recording device and an image recording system having  
a plurality of laser beams (multi-laser beam).

**10 (Background of the Invention)**

An image-recording device using a laser beam has  
been widely used because it runs faster with a higher  
resolution than image-recording devices of the other  
technologies.

**15 A conventional printer using one laser beam (laser  
printer) is disclosed in Japanese patent application  
laid-open publication No. Hei 8-310057 (1996). The  
printer utilizes features of continuously modulating  
laser intensities in the main scanning direction and  
20 controlling the quantity of attached toner by laser  
intensities for high-resolution printing. These  
features eliminate and reduce smooth the  
irregularities in slanted outlines of characters and  
images, which makes the printout images and characters  
25 smooth.**

To run the laser beam printer faster, it is required to make the laser beam (the light beam of a laser) scan at high speed in both main scanning direction (horizontally) and subsidiary scanning direction (vertically).

These may be accomplished by rotating a photosensitive drum (for vertical scanning) and a rotary polygon mirror (for horizontal scanning) at high speeds. However, the rotational speed of the polygon mirror of the conventional fastest laser beam printer using one laser beam is almost closest to the limit. Therefore, a multi-beam method of causing two or more laser beams to scan simultaneously is used instead of increasing the rotational speed of the polygon mirror.

Most laser beam printers (particularly printing systems that may be easily affected by the environmental conditions such as in electrophotography) frequently employ a method of varying the pulse duration (width) of a laser drive signal by modulation (PWM) and thus controlling the quantity of light (that is, controlling the print dot sizes by light control) for assurance of picture qualities and stability when they print out multi-level images having pixels whose dot sizes (image

data) are multi-leveled (gradated).

There are two methods of generating this pulse-width-modulated laser drive signal (pulses): Analog method of generating by comparing a triangular wave  
5 created in synchronism with image data by the D/A converter output of the image data, for example, as disclosed in Japanese patent application laid-open publication No. Sho 62-39972 (1987) and Digital method  
of generating logically (by frequency-division) from a  
10 fast clock whose frequency is 4 to 8 times as high as the image clock as disclosed in Japanese application patent laid-open publication No. Hei 5-6438 (1993).

As described above, a fast printer system for printing multi-level images is typically of a multi-  
15 beam method using a pulse-width modulation technique.

Although a laser printer using a multi-beam method is disclosed in Japanese application patent laid-open publication No. Hei 8-15623 (1996), this method may  
reduce the image accuracy according to uneven dot  
20 sizes if the light quantities of the laser sources are not equal. To solve such a problem is proposed a technique for correcting light quantities of laser sources.

For example, Japanese application patent laid-open  
25 publication No. Hei 5-212904 (1993) discloses a method

of applying a driving signal of an identical pulse width to the driving circuit of each laser source which emits illuminating dots, measuring the intensity of each illuminating dot, and calculating light  
5 correction values from the measured intensities of light (light dispersion). (This example calculates the ratio of the maximum value  $X_{max}$  of the light quantity data to the minimum value  $X_{min}$ , multiplies the image data  $L$  by the ratio, multiplies the product by a  
10 correction factor  $X_{min}/X$  for each illuminating dot calculated from the light quantity data  $X$  and the minimum value  $X_{min}$ , and thus obtains the corrected image data  $L$ .)

There is disclosed another embodiment in Japanese  
15 application patent laid-open publication No. Hei 7-199096 (1995). The embodiment detects the quantity of a laser light from each laser source by a sensor, compares it by a preset target value, and controls the current of each laser source so that the quantities of  
20 laser lights from the laser sources may be identical.

#### SUMMARY OF THE INVENTION:

(Disclosure of the Invention)

An image recording device using two or more laser  
25 beams has the following two problems pointed out:



One problem is that the positional accuracy of beam spots in the subsidiary scanning direction is low. This may be mainly caused by the following:

- 5 (1) Influence due to the positional accuracy of the multi-beam structure
- (2) Influence due to the horizontal magnification error in the optical system
- (3) Influence due to the surface angle error of the polygon mirror

10 These factors cause uneven intervals of beam spots. In other words, scanning lines are dense in some places and thin in the other places. This scanning line trouble is called a scanning unevenness. The scanning uneven causes exposure unevenness. When  
15 developed and visualized, the unevenness may be recognized as a visual unevenness.

The period of generation of this unevenness is dependent upon the product of the number of laser beams by the number of faces of the polygon mirror.

20 This unevenness occurs depending upon said product and the subsidiary scanning period of a tone dither pattern to represent an area gradation and gives an influence to a low-frequency area which is more sensitive to the visual characteristics of human. This  
25 problem also occurs by the uneven light quantities of

laser beams.

The other problem is that the positional accuracy of beam spots in the main scanning direction is low. The position of a beam spot in the main scanning direction is usually detected by a beam detector at the beginning of each scanning line. In a laser beam printer system using a single laser beam, the exact position of a beam spot can be detected because the intensity of the beam spot, the intensity distribution and the position relative to the beam detector are fixed. Contrarily, in a laser beam printer system using two or more laser beams, the beam spot positions in the main scanning direction cannot be exact because the intensity of the beam spot, the intensity distribution and the position relative to the beam detector are not fixed. This problem is called a scanning jitter.

These problems are specific for laser beam printer devices using two or more laser beams and rarely occurs in laser beam printer devices using a single laser beam.

In a laser beam image recording device using a single laser beam, the positional accuracy of spot beams in the subsidiary direction is within the allowable visual characteristic range and such a

problem will not occur in the main scanning direction.

An object of the present invention is to obtain high-quality high-resolution recording images without scanning unevenness and scanning jitters in a laser beam image recording device using two or more laser beams.

To attain said purpose, said image recording device according to the present invention is equipped with a plurality of light sources and a photosensitive drum which is exposed by said light sources. Said device is further equipped with a block for setting the quantity of interfered lights of a plurality of image signals corresponding to said light sources, a block for interfering only said set light quantity component of said image signal, a block for setting delays of a plurality of image clocks corresponding to said light sources, a block for delaying said image clocks by said set time period, a memory block for storing interference data output from said interference block in synchronism with said image clocks and for outputting said interference data in the order the data was stored by delay data output from said delay block, and a block for varying the pulse duration (width) of interference data output from said memory block by modulation.

The interference light quantity setting block detects a positional error of beam spots in the subsidiary scanning. Its light quantity component is interfered by the interference block and its pulse width is modulated by the pulse-width modulating block. With this, the positional error in the subsidiary scanning is corrected. Said delay time setting block detects a positional error of beam spots in the main scanning and sets a time period required to correct the error. The delay block delays said image clocks by a preset time period and the pulse width is modulated by the pulse width modulating block. With this, the positional error in the main scanning is corrected. The resulting recorded images are high-quality and high-resolution images without scanning unevenness and scanning jitters even when two or more light sources are used.

Further, an image recording device equipped with a plurality of pulse-width modulators for modulating pulse widths of a plurality of laser driving signals according to the image data and a plurality of laser light sources for outputting a plurality of laser beams whose light quantities are controlled by these laser driving signals to record images by scanning these plurality of laser beams has a means for

detecting unevenness in pulse-width modulation of said plurality of laser driving signals and correcting said plurality of laser driving signals according to the degrees of unevenness.

5        When the pulse widths (modulated values) of laser driving signals for laser driving circuits are not identical due to unevenness of circuit characteristics such as pulse width modulators in said image recording device employing a multi-beam method and a pulse-width  
10        modulation, the aforesaid configuration corrects the laser driving signals according to the unevenness of pulse widths (pulse-width modulation values) not to give any influence by the unevenness of the pulse width modulation to the images (print dot sizes)  
15        formed by laser beams.

      This configuration is also designed to correct widths of pulses output from the pulse generating blocks by causing the pulse generating blocks to generate pulses in synchronism, comparing the width of  
20        pulses output from each pulse generating block by the reference pulse width, and controlling the pulse generating blocks to eliminate the difference between them.

      Correction of pulse widths of each pulse  
25        generating block according to the present invention is



done by selecting a preset number of serially-  
connected delay elements in a pulse width controlling  
block.

It is preferable to use pulses of one of pulse  
5 generating blocks as the reference pulses and to give  
an identical image clock in common to the pulse  
generating blocks when causing the pulse generating  
blocks to generate pulses in synchronism.

As said configuration corrects to equalize the  
10 widths of pulses output from the pulse width  
modulators which work to set light quantities of laser  
beams, their print dot sizes can be equalized and  
consequently image data can be recorded at high  
resolution.

15 Said image recording device according to the  
present invention is equipped with a plurality of  
light sources and a plurality of beam detecting blocks  
and further equipped with a block for recording an  
image, a block for outputting a beam position control  
20 signal to control the position of each laser beam  
between scanning lines according to a plurality of  
beam detection signals output from said image  
recording block and a controller for controlling said  
image recording block according to said beam position  
25 control signals.

The beam signal controlling block provided as explained above can correct positional deviations of said laser beams and thus enables the image recording device to record high-quality images.

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#### BRIEF DESCRIPTION OF THE DRAWINGS

FIG. 1 is a block diagram showing an embodiment of a correction circuit of an image recording device according to the present invention.

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FIG. 2 is an illustration showing an embodiment of an image recording device according to the present invention.

FIG. 3 is an illustration explaining an exposure system using a plurality of beams.

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FIG. 4 is an illustration explaining synchronization of signals between the controller and the engine.

FIG. 5 is a waveform diagram of the synchronizing signals.

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FIG. 6 shows a graph of the output characteristics of the beam detector.

FIG. 7 is an illustration explaining a scanning unevenness.

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FIG. 8 shows an embodiment of an image recording device according to the present invention.

FIG. 9 shows an embodiment of a correcting procedure of a correcting circuit of an image recording device according to the present invention.

5      FIG. 10 is an illustration explaining test patterns for measuring a positional error in the subsidiary scanning direction according to the present invention.

10      FIG. 11 shows the result of measurement of a positional error in the subsidiary scanning direction according to the present invention.

FIG. 12 shows an embodiment of an image recording device system measuring a positional error in the subsidiary scanning direction according to the present invention.

15      FIG. 13 shows an embodiment of an interference circuit of a correction circuit according to the present invention.

20      FIG. 14 shows another embodiment of an interference circuit of a correction circuit according to the present invention.

FIG. 15 is an illustration explaining the principle of correcting the scanning line pitch in the correction method according to the present invention.

25      FIG. 16 is an illustration explaining test patterns for measuring a positional error in the main

scanning direction according to the present invention.

FIG. 17 shows the result of measurement of a positional error in the main scanning direction according to the present invention.

5        FIG. 18 shows an embodiment of a delay circuit of a correction circuit according to the present invention.

FIG. 19 is an illustration explaining operations of optical density sensors.

10        FIG. 20 is an illustration explaining correction of a scanning line pitch by the correction circuit according to the present invention.

FIG. 21 shows another embodiment of an interference circuit of a correction circuit according to the present invention.

FIG. 22 is an illustration explaining the scanning line unevenness and the spot light unevenness.

FIG. 23 shows an embodiment of a waveform of a synchronizing signal of a correction circuit according to the present invention.

FIG. 24 is an illustration explaining a means of setting the quantity of interference light of the correction circuit according to the present invention.

FIG. 25 shows an embodiment of the pulse-width modulation circuit of the correction circuit according

to the present invention.

FIG. 26 shows the result of operation of the pulse-width modulation circuit of FIG.25.

5      FIG. 27 is an illustration explaining a means of setting a delay time of the correction circuit according to the present invention.

FIG. 28 shows an embodiment of a FIFO register of the correction circuit according to the present invention.

10      FIG. 29 is an illustration explaining tilting of faces of the rotary polygon mirror which is one of problems of this invention.

15      FIG. 30 shows a secondary embodiment of the correcting procedure of the correction circuit according to the present invention.

FIG. 31 shows a tertiary embodiment of the correcting procedure of the correction circuit according to the present invention.

20      FIG. 32 shows an embodiment of a laser array according to the present invention.

FIG. 33 shows an example of configuration of a laser array of FIG. 32.

FIG. 34 shows an embodiment of light-quantity control by the laser array of FIG. 32.

25      FIG. 35 is an illustration explaining the



embodiment of a scanning method of the laser array of FIG. 32.

FIG. 36 is an illustration explaining the visual characteristics of human.

5        FIG. 37 is an illustration explaining a sequence of measurement of initial characteristics of a laser array according to the present invention.

FIG. 38 shows another embodiment of an image recording device according to the present invention.

10        FIG. 39 shows an embodiment of a controller according to the present invention.

FIG. 40 is a detailed block diagram of controller of FIG. 39.

15        FIG. 41 shows an embodiment of a device for correcting laser driving signals of FIG. 40.

FIG. 42 shows an operational flow chart of a device for correcting laser driving signals of FIG. 40.

20        FIG. 43 is an illustration explaining the relationship between currents supplied to a light sources and dot sizes printed on paper sheets.

FIG. 44 shows an embodiment of a target value detecting block of FIG. 41.

FIG. 45 shows an operational flow chart of a target value detecting block of FIG. 41.

25        FIG. 46 shows an embodiment of a processing block

of FIG. 41.

FIG. 47 shows an operational timing chart of the processing block of FIG. 46.

FIG. 48 shows an embodiment of a block for  
5 converting light-quantity correction data of FIG. 41.

FIG. 49 shows an operational timing chart of the block for converting light-quantity correction data of FIG. 48.

FIG. 50 shows an embodiment of a minimum value  
10 detecting block of FIG. 41.

FIG. 51 shows an embodiment of a pulse-width modulation (PWM) of FIG. 40.

FIG. 52 shows an operational timing chart of the pulse-width modulation (PWM) of FIG. 51.

FIG. 53 shows another embodiment of a controller  
15 according to the present invention.

FIG. 54 is a detailed block diagram of the controller of FIG. 53.

FIG. 55 shows an embodiment of a multi-level  
20 correction unit of FIG. 54.

FIG. 56 shows an embodiment of a block for converting light-quantity correction data of FIG. 55.

FIG. 57 shows an operational timing chart of the block for converting light-quantity correction data of  
25 FIG. 56.

FIG. 58 shows an embodiment of a pulse-width modulation (PWM) of FIG. 54.

FIG. 59 shows an embodiment of a delay time selecting block of FIG. 58.

5        FIG. 60 shows an operational timing chart of a pulse-width modulation (PWM) of FIG. 54.

FIG. 61 shows an embodiment of a controller according to the present invention.

10       FIG. 62 shows a detailed block diagram of a controller of FIG. 61.

FIG. 63 shows an embodiment of a pulse-width modulation (PWM) of FIG. 62.

FIG. 64 shows an embodiment of a pulse-width adjusting block of FIG. 63.

15       FIG. 65 shows an embodiment of a pulse-width correcting device of FIG. 61.

FIG. 66 shows an embodiment of an image clock selecting block of FIG. 61.

20       FIG. 67 shows an operational timing chart of an image recording device according to the present invention.

FIG. 68 shows an operational timing chart of an image recording device according to the present invention.

25       FIG. 69 shows an operational timing chart of a

pulse-width modulation (PWM) of FIG. 62.

FIG. 70 shows the relationship between image data and print dot sizes according to the present invention.

FIG. 71 shows another embodiment of an image clock selecting block according to the present invention.

FIG. 72 shows an embodiment of a block for controlling the position of a laser beam detection signal according to the present invention.

FIG. 73 shows an embodiment of a delay time control circuit according to the present invention.

FIG. 74 shows an embodiment of a circuit for generating a variable-position signal according to the present invention.

FIG. 75 shows an embodiment of a circuit for generating a fixed-position signal according to the present invention.

FIG. 76 shows an embodiment of a positional signal selecting circuit according to the present invention.

FIG. 77 shows an embodiment of a beam detection signal delaying circuit according to the present invention.

FIG. 78 shows an operational timing chart of a delay circuit for a positional test according to the present invention.

FIG. 79 shows a basic pattern according to the

present invention.

FIG. 80 shows an example of test chart data according to the present invention.

FIG. 81 shows an example of printed pattern in the  
5 absence of a beam scanning error according to the present invention.

FIG. 82 shows an example of printed pattern in the presence of a beam scanning error according to the present invention.

10 FIG. 83 shows another example of a printed pattern in the presence of a beam scanning error according to the present invention.

FIG. 84 shows a printout example of a test chart according to the present invention.

15 FIG. 85 shows another embodiment of an image recording device according to the present invention.

FIG. 86 shows another embodiment of a block for controlling the position of a laser beam detection signal according to the present invention.

20 FIG. 87 shows another example of a basic pattern according to the present invention.

FIG. 88 shows another example of a printed pattern in the presence of a beam scanning error according to the present invention.

25 FIG. 89 shows another embodiment of an image



recording device according to the present invention.

FIG. 90 shows another embodiment of an image recording device according to the present invention.

FIG. 91 shows another embodiment of an image  
5 recording device according to the present invention.

#### DESCRIPTIUON OF THE INVENTION:

(Best Mode of Carrying Out the Invention)

Referring to FIG. 1 to FIG. 18 and FIG. 22 to FIG.  
10 28, preferred embodiments of the present invention are explained.

In FIG. 2, there is shown an operating environment of a general image recording device. The user creates page description data 202 which represents pages to be  
15 recorded using a computer 201 and the like. When recording starts, the page description data 202 is sent to a printer controller 203 of an image recording device 200 through a network and the like. The image recording device 200 mainly consists of a printer  
20 controller 203 and an engine 205. The printer controller 203 expands page description data 202 page by page as image data 207 on built-in bit-map memory.

This embodiment assumes that image data 207 is printed on a monochromatic binary laser printer and  
25 one piece of binary data is related to one bit of one

pixel. After expansion of image data 207 is completed,  
the printer controller 203 starts the engine 205 of  
the image recording device 200 and sends image data  
207 as a video signal 204 to the engine 205 according  
5 to synchronization signals from the engine 205. The  
engine 205 records actual images on a recording medium  
according to video signals 204.

FIG. 3 shows a detailed exposure system of the  
engine 205 of FIG. 2. For purpose of simplification,  
10 this embodiment assumes that the engine 205 is a  
monochromatic binary multi-beam laser printer. Below  
is explained only the exposure system related to the  
present invention. This embodiment assumes the  
exposure system has four laser beams and a rotary  
15 polygon mirror 302 of eight faces.

As disclosed in Japanese application patent laid-  
open publication No. Hei 8-15623 (1996), four laser  
beams 301 are provided by either providing four laser  
sources or dividing one laser beam into four beams and  
20 emitted onto a rotary polygon mirror 302. Four laser  
sources 310 are provided to have four laser beams as  
shown in FIG. 3.

Each of the laser sources 310 usually consists of  
a semiconductor laser and its driver. Video signals  
25 VD1, VD2, VD3, and VD4 are applied to the laser

sources 310. When one laser beam is divided into four beams, the laser beams are modulated by AO modulators which are not illustrated in the drawing. As illustrated in FIG. 3, four laser beams 301 are  
5 focused onto the surface of the photosensitive drum 303 to form four beam spots 306, 307, 308, and 309 there. As the rotary polygon mirror 302 rotates, the beam spots move along the main scanning direction.

One scanning forms four scanning lines 304 at a  
10 time as four laser beams are applied to the mirror. Therefore, the photosensitive drum rotates by four scanning lines for each scanning. The direction opposite to the direction of rotation of the photosensitive drum 303 is termed as a subsidiary  
15 scanning direction. The subsidiary scanning direction is perpendicular to the main scanning direction. Laser beam spots formed on the surface of photosensitive drum 303 are numbered 1, 2, 3, and 4 from the  
20 In FIG.3, beam spots 1, 2, 3, and 4 are beam spots 306, 307, 308, and 309.

Problems the present invention is going to solve will be explained in detail below. One problem is that the positional accuracy of beam spots in the  
25 subsidiary scanning direction is low. When a plurality

of light sources are used, the positional accuracy of beam spots in the subsidiary scanning direction is dependent upon a combination of the structural accuracy of the light sources and the scanning faces  
5 of the rotary polygon mirror.

For example, when four semiconductor laser elements are molded into a unit, it is very hard to exactly line up four light emitting points at equal intervals. Similarly when one laser beam is divided  
10 into four beams, it is very hard to exactly generate four laser beams.

In addition to this, irregular mirror face tilting makes the positional accuracy of beam spots worse. The four laser beams pass through a common scanning  
15 optical system while changing their axes finely by these structural irregularities. Consequently, the laser beams have different intensities and intensity distributions, which causes positional errors of beam spots in the subsidiary scanning direction on the  
20 photosensitive drum 303 and finally makes irregular scanning line pitches.

FIG. 7 shows examples of positional errors of beam spots (irregular scanning line pitches) in the subsidiary scanning direction due to structural  
25 irregularities. Numbers 1, 2, 3, and 4 represent beam

spot numbers. These irregular pitches of scanning lines 304 are caused by positional errors due to the structural irregularity of the optical system. In example (1) of FIG. 7, the scanning line pitch made by beam spots 1, 2, and 3 is narrow but that made by beam spots 3 and 4 is wide.

In example (2) of FIG. 7, the scanning line pitch made by beam spots 1, 2, 3, and 4 is constant but that made by beam spots 4 and 1 is wide. This is because the rotational speed of the photosensitive drum 303 is not equal to the subsidiary scanning line speed. The scanning line unevenness which periodically occurs every number of laser beams may drastically deteriorate the image quality because it causes density unevenness such as a moire pattern when half tones are recorded with dots and their distances and periods get matched or almost matched.

FIG. 22 shows the uneven dot densities caused by irregular scanning line pitches. This example shows a brighter part of a half-tone image made by dots. Usually smaller dots are used to represent a brighter part. FIG. 22 assumes that the dot centers are disposed periodically at intervals of four scanning lines (by  $n$  times where  $n$  is 1, 2, 3, ...) in the subsidiary scanning direction.



If the scanning lines are irregularly pitched as shown in FIG. 7 (1), said dots may be disposed as shown in FIG. 22 (1), FIG. 22 (2), or in an intermediate status of them. In (1) of FIG. 22, dots  
5 are made smaller and the half-tone image becomes brighter. Contrarily in (2) of FIG. 22, dots are made greater and the half-tone image becomes darker. Further as the video signal is not in synchronism with the irregular scanning line pitches, the image may  
10 have patches of different intensities. Such a symptom occurs also in the slant edges of characters, makes characters and images unsmooth, and consequently the image quality is reduced.

The problem may be also caused by a structural  
15 irregularity (a face tilting) of the rotary polygon mirror 302. FIG. 29 shows how a face tilting of the rotary polygon mirror 302 causes an irregularity of scanning line pitches on the surface of the photosensitive drum 303. The optical system in FIG.29  
20 employs a complete correction system using a cylindrical lens 2903 in which the scanning faces of the rotary polygon mirror 302 are optically conjugated with the photosensitive drum 303.

As laser beams are usually applied to the scanning  
25 surface of the mirror at a certain angle to the

optical axis which is illustrated in FIG. 29, the illustrated position on the rotary polygon mirror 302 moves left and right and thus the complete conjugate system is destroyed. This is also affected by the  
5 astigmatism of the lens. As the result, a pitch irregularity  $\delta$  is formed on the photosensitive drum between a scanning line made by a laser beam 2901 from a non-tilted mirror face and a scanning line made by a laser beam 2902 from a tilted mirror face. The  
10 aforesaid description is for a complete correction optical system.

Recently for purpose of simplification of an optical system, there increases the number of image recording devices using an incomplete correction  
15 optical system without a conjugate system. However, the aforesaid trouble may be more serious in such systems. This pitch irregularity  $\delta$  is caused by a lens correction astigmatism affected by both the structural irregularity of laser beams and the structural  
20 irregularity of the rotary polygon mirror 302. Accordingly, the degree of its influence (irregular scanning line pitches) varies according to the tilting of each mirror face.

The irregular scanning line pitches cause uneven  
25 exposures. When such an image is developed and

visualized, the unevenness is recognized as visual patches in the image. Similar problems may occur also by irregular light quantities of laser beams.

5 The other problem is that the positional accuracy of beam spots in the main scanning direction is low. Beam spot scanning positions 306 to 309 in the main scanning direction are usually detected by a beam detector 305 at the top of each scanning line 304. A beam detector 305 is provided at the beginning of each  
10 scanning 304 and generates four different beam detection signals BD for each scanning as beam spots 1 to 4 scan across the beam detector 305.

Usually, beam spot scanning positions 306 to 309 are much deviated from each other in the main scanning  
15 direction to make the scanning line pitch 304 smaller. In this embodiment, beam spot 1 is positioned right most and beam spots 2 to 4 follows to the left of beam spot 1 at intervals. Therefore, the beam detector 305 first generates a pulse signal BD1 by a laser beam 1  
20 and then generates the other pulse signals BD2, BD3, and BD4 in this sequence in a short time period. Referring FIG. 4 to FIG. 6, the possible causes to make the positional accuracy of beam spots worse in the main scanning direction will be explained.

25 FIG. 4 shows the exchange of synchronization

signals between the printer controller 203 and the engine 205. In this example, the aforesaid beam detection signals BD are equivalent to a synchronization signal 206. The printer controller 203 receives a signal BD from the engine 205 and separates signals BD1, BD2, BD3, and BD4 from the signal. This signal separation is disclosed in Japanese application patent laid-open publication No. Hei 8-15623 (1996). The printer controller 203 generates pixel clocks DCLK1, DCLK2, DCLK3 and DCLK4 (not illustrated) in phase-synchronism with these synchronization signals BD1, BD2, BD3, and BD4, generates video signals VD1, VD2, VD3, and VD4 corresponding to laser sources 310 in synchronism with the pixel clocks DCLK1, DCLK2, DCLK3 and DCLK4, and sends the video signals to the engine 205.

FIG. 5 shows waveforms of synchronization signals BD1, BD2, BD3, and BD4, pixel clocks DCLK1, DCLK2, DCLK3, and DCLK4, and video signals VD1, VD2, VD3, and VD4. A time period  $\Delta t$  between each synchronization signal BD and its pixel clock DCLK is retained exactly constant. Each video signal VD is sent exactly in synchronism with its pixel clock. With these, the beam spot scanning positions 306 to 309 are adjusted to the recording positions.

However, in the multi-beam image recording device, intensities and intensity distributions of beam spots may be different. The position of each beam spot relative to the center of the beam detector 305 may be different. (In a 4-beam system, inner two beam spots are necessarily closer to the center of the beam detector than the outer two beam spots.)

Further, each beam spot has a different relationship between the position of each beam detection signal BD and the actual position of a beam spot in the main scanning direction because the positions of beam spots in the subsidiary scanning direction are different as described above. Finally, a positional error occurs in the main scanning direction.

FIG. 6 shows the outputs of the beam detector 305 which receives a beam spot having a wide intensity distribution (a) and a beam spot having a narrow intensity distribution (b). The difference in intensity distributions is dependent upon spot diameters and light emitting powers (light intensities). The beam detector 305 receives each laser beam at a photo diode or the like, converts its intensity into an analog electric signal, digitizes it at a certain level (threshold), and outputs a binary digital value.



Even when two beam spots have an identical center position, the analog output of a beam spot having a narrow intensity distribution (b) rises more sharply than the analog output of a beam spot having a wide intensity distribution (a). When the analog outputs are digitized at a threshold value as shown in FIG. 6, the binary output of (a) rises earlier. Generally, considering the sensitivity distribution of the light receiving part of the beam detector 305, the positional error of beam spots may occur when the positions of beam spots relative to the beam detector 305 differ. With this, the explanation of problems which the present invention is going to solve is completed.

In the following examples are described several preferred embodiments of this invention to solve the aforesaid problems.

FIG. 8 shows a configuration of an engine of an image recording device of the present invention. The photosensitive drum 303 is uniformly charged by a charger 801 and scanned with laser beams from an exposure optical system 802 according to video signals 204. An image on the surface of the photosensitive drum is developed by means of toner from the developer 804.

Immediately before development, the surface potentiometer 803 measures the surface potential on the photosensitive drum 303. The surface potentiometer 803 requires an area of 1 cm square for measurement and measures the average potential of the area.

For purpose of simplification, the following example assumes that it is not affected by face tilting of the rotary polygon mirror.

FIG. 9 shows a correction procedure of the present invention. This correction procedure starts when the image recording device is powered on or when a job starts. First the exposure optical system 802 exposes a test pattern for measuring positional errors of adjoining beam spots in the subsidiary scanning direction spot by spot onto the surface of the photosensitive drum 303.

Next, the surface potentiometer 803 measures the surface potential on the exposed photosensitive drum 303. As the mean surface potential of beam spots whose distance in the subsidiary scanning direction is narrow is not equal to the mean surface potential of beam spots whose distance in the subsidiary scanning direction is wide, the positional error of beam spots in the subsidiary scanning direction can be calculated from the difference between the aforesaid mean surface

potentials.

By adding a video signal to or subtracting it from the light quantity of an adjoining beam according to the result of calculation, the position of beam spots  
5 in the subsidiary scanning direction can be corrected.

The light quantity of a beam to be added or subtracted is termed as an interference light quantity.

The exposure optical system 802 exposes a test pattern for measuring positional errors of adjoining  
10 beam spots in the main scanning direction spot by spot onto the surface of the photosensitive drum 303. Next, the surface potentiometer 803 measures the surface potential on the exposed photosensitive drum 303.

In the same manner as the above, the difference  
15 between the aforesaid mean surface potentials is calculated to get a positional errors of beam spots in the main scanning direction. By adding a video signal to or subtracting it from the light quantity of an adjoining beam according to the result of calculation,  
20 the position of beam spots in the main scanning direction can be corrected.

With these operations, positional errors in the main and subsidiary scanning directions are eliminated and consequently high-quality high-resolution images  
25 can be obtained. Below are explained details of each

part in FIG. 9.

The second column of the table of FIG. 10 shows test patterns for measuring positional errors of beam spots in the subsidiary scanning direction. This embodiment uses a test pattern for measuring the distance between beam spots 1 and 2. To accomplish this, the exposure optical system 802 exposes beam spots 1 and 2 by video signals VD1 and VD2 (see FIG. 4) of "1" (black) and unexposes the other beam spots 3 and 4 by video signals VD3 and VD4 of "0" (white).

When this test pattern is recorded on a 1cm-square area of the photosensitive drum surface, the surface potentiometer 803 (see FIG. 8) can measure the mean surface potentials of the patterns. The elliptic areas of test patterns (in the second column of the table of FIG. 10) are exposed areas and their surface potentials are low. Generally, the surface of the photosensitive drum 303 is uniformly charged to about -600 volts by the charger 801.

When the charged photosensitive drum is exposed to a laser beam, the potential of the exposed areas on the charged surface goes down. However the quantity of a voltage drop to the quantity of exposure is apt to be saturated and the quantity of exposure for beam spots is strong enough for saturation.

Therefore the elliptic areas of test patterns (in the second column of the table of FIG. 10) has a saturated potential (-50 volt for this embodiment) which is termed as a residual potential. However, the surface potentiometer 803 does not have an ability to identify potential differences of scanning lines and takes the average of the potentials.

The first column of FIG. 10 shows different scanning line pitches: standard line pitch B of 42  $\mu\text{m}$ , narrow line pitch A of 32  $\mu\text{m}$ , and wide line pitch C of 53  $\mu\text{m}$ . The third column of FIG. 10 shows their mean surface potentials measured by the surface potentiometer 803.

As seen from this table, the mean surface potential goes lower (that is, the absolute value of the negative potential increases) as the line pitch becomes smaller. This is dependent upon the ratio of the exposed area whose potential is reduced to -50 volts (elliptic area in FIG. 19) to the unexposed area whose potential remains at -600 volts.

The fourth column of the table in FIG. 10 shows the approximate ratios of the elliptic areas calculated from the test patterns given in the second column of the table. As seen from these ratios, as the scanning line pitch goes narrower, the exposed area



becomes smaller and the mean surface voltage remains low.

The mean surface voltages in the third column of the table are examples. Their magnitudes are dependent upon charging and exposing conditions.

However, the relationship between scanning line pitches and mean surface potentials which are measured under an identical condition remains unchanged. In other words, scanning line pitches are always identical as far as mean surface potentials are identical. This characteristic can be used for correction of irregular scanning line pitches.

Although FIG. 10 shows test patterns for measuring the distance between beam spots 1 and 2 and the result of measurement of their surface potentials, the similar test patterns can be used for each pair of the other beam spots (2 and 3, 3 and 4, and 4 and 1) and the similar results of measurement of surface potentials can be obtained.

Example (1) of FIG. 11 shows an example of the result of measurement of surface potentials V12, V23, V34, and V41 in the execution of test patterns for measuring the distance of each pair of beam spots (1 and 2, 2 and 3, 3 and 4, and 4 and 1) in the subsidiary scanning direction.

This example shows that the distance between beam spots 2 and 3 is wide and that between beam spots 4 and 1 is narrow. When a correction is made to make all these surface potentials V12, V23, V34, and V41 identical as shown in Example (2) of FIG. 11, the scanning line distances become identical (42  $\mu$ m). A correcting procedure is explained below referring to FIG. 1, FIG. 12 to FIG. 15, and FIG. 23.

FIG. 12 shows the system configuration of an image recording device of the present invention. The printer controller 203 sends synchronization signals BD1, BD2, BD3, and BD4, pixel clocks DCLK1, DCLK2, DCLK3, and DCLK4, and video signals VD1, VD2, VD3, and VD4 corresponding to laser light sources 310 to the correction circuit 1201 of the present invention.

The correction circuit 1201 corrects the video signals VD1, VD2, VD3, and VD4 into VDe1, VDe2, VDe3, and VDe4 and outputs the corrected video signals to the engine 205. The correction circuit can be placed in the output part of the printer controller 203 or in the input part of the engine 205. These signals are already explained in FIG. 4 and FIG. 5. However, in the image recording device of the present invention, the video signals VD1, VD2, VD3, and VD4 are sent differently. They are explained in detail below.

FIG. 23 shows waveforms of synchronization signals of the present invention. The main difference is in that video signals VD1, VD2, VD3, and VD4 are all sent in synchronism with the pixel clock DCLK1. The  
5 correction circuit 1201 modulates the video signals, generates new video signals VDe1, VDe2, VDe3, and VDe4 respectively in synchronism with the pixel clocks DCLK1, DCLK2, DCLK3 and DCLK4, and supplies them  
10 respectively to the laser light sources 310 of the engine 205.

The configuration of the correction circuit 1201 of the present invention is illustrated in FIG. 1. The video signals VD1, VD2, VD3, and VD4 from the printer controller 203 are fed to the interference circuit 101.  
15 The interference circuit 101 causes the signals to interfere with each other by a light-quantity component preset by a means 102 which determines the quantity of an interfering light of video signals and converts the signals respectively to VDd1, VDd2, VDd3,  
20 and VDd4. The signals VDd1, VDd2, VDd3, and VDd4 output from this circuit example are 2-bit digital signals.

These signals are sent to the inputs of 2-bit FIFO (First-In First-Out) memory 103 and written there in  
25 synchronism with the pixel clock DCLK1. On the other

hand, pixel clocks DCLK1, DCLK2, DCLK3, and DCLK4 are sent from the printer controller 203 to the delay circuit 104. The delay circuit delays each pixel clock by a time period set by a means 105 which determines a delay time period for each pixel clock and outputs the resulting pixel clocks DCLKd1, DCLKd2, DCLKd3, and DCLKd4 to the outputs of 2-bit FIFO (First-In First-Out) memory 103.

These pixel clocks are used to read signals VDd1, VDd2, VDd3, and VDd4. The signals VDd1, VDd2, VDd3, and VDd4 from FIFO memory 103 are fed to the pulse modulation circuit 106, modulated there into video signals VDe1, VDe2, VDe3, and VDe4, and output to the engine 205. The interference circuit 101 and FIFO memory 103 work to correct positions of beam spots in the subsidiary scanning direction and the delay circuit 104 and FIFO memory 103 work to correct positions of beam spots in the main scanning direction.

FIG. 13 shows an explanatory diagram of the interference circuit 101. The interference circuit 101 generates signals VDd1, VDd2, VDd3, and VDd4 from video signals VD1, VD2, VD3, and VD4 and a  $4 \times 4$  matrix A of actual coefficients which are set by a means 102 for determining the interference light quantity. A coefficient "a<sub>ij</sub>" represents a component

of a signal transferred from a signal  $VD_i$  to a signal  $VD_dj$  (where "i" and "j" are 1, 2, 3, or 4).

Substantially, in FIG. 13, a  $4 \times 1$  signal vector ( $VD_d1$ ,  $VD_d2$ ,  $VD_d3$ , and  $VD_d4$ ) is obtained by  
5 multiplying a  $4 \times 1$  matrix having signals  $VD_1$ ,  $VD_2$ ,  $VD_3$ , and  $VD_4$  as its components by the matrix A. As Non-diagonal components (other than "a<sub>ii</sub>") of the matrix A work to interfere with the adjoining beam spots, this circuit is termed an interference circuit  
10 101. This circuit can be an analog circuit such as an amplifier or adder or a digital circuit such as a computing unit (CPU) and ROM.

FIG. 15 shows a principle of correction for determining coefficients of the matrix A of FIG. 13.  
15 The X-axis of the graph represents the position of scanning lines 1, 2, and 3 made by beam spots 1, 2, and 3 in the subsidiary scanning direction. The Y-axis of the graph represents the quantity of exposure of a beam spot 2 on the surface of the photosensitive drum  
20 by the video signal  $VD_2$ .

In Examples (1) and (2) of FIG. 15, the distance (pitch) between the scanning lines 1 and 2 is greater than the standard scanning line pitch and the distance (pitch) between the scanning lines 2 and 3 is smaller  
25 than the standard scanning line pitch.



Example (1) of FIG. 15 shows the distribution of light exposed in a conventional technique and the position of a pixel 1503 which is developed by the developer 804. Assuming that a position whose exposure quantity is over a preset threshold value 1502 (indicated by a dotted line) is developed by the developer 804, the position of a pixel 1503 to be developed necessarily moves toward the scanning line 3 as the exposure distribution part 1501 over the threshold level 1502 is developed.

To move left the pixel made by the scanning line 2, the image recording device of the present invention adds one part of the component of the video signal VD2 for the scanning line 2 to the component of the video signal VD1 for the scanning line 1 and contrarily subtracts the component of the video signal VD2 for the scanning line 2.

In the matrix A of FIG. 13,  $a_{22}$  is 0.7 and  $a_{21}$  is 0.5. As the result, although the intensity distribution of a beam spot usually is a Gaussian distribution (normal distribution) as shown in Example (2) of FIG. 15, the exposure component 1504 of the scanning line 1 and the exposure component 1505 of the scanning line 2 are optically added to form a new exposure distribution 1506. Therefore, the new

exposure distribution 1506 is above the threshold level 1502 and the position of the developed pixel 1507 according to present invention becomes optimum.

FIG. 24 shows an example of means 102 for  
5 determining the quantity of interference light. FIG. 24 (1) shows the result of potential measurement which is the same as FIG. 11 (1). The means 102 calculates the difference between each surface potential (V12, V23, V34, and V41) and the average  $V_a (= (V12 + V23 + V34 + V41) / 4)$  and judges whether the distance  
10 between each pair of scanning lines is small or large. In this example, the distance between the scanning lines 2 and 3 is wide and the distance between the scanning lines 4 and 1 is narrow. The means 102  
15 determines the quantity of interference light as shown in FIG. 24 (2).

First the means 102 corrects the distance between the scanning lines 2 and 3. This example assumes that the quantity of correction "d23" is  $V_a - V23$ . The  
20 interference coefficients "a23" and "a32" are respectively obtained by adding the product of "k1" by "d23" to the old coefficients "a23" and "a32." For the first correction, coefficients "a23" and "a32" are respectively 0. The interference coefficients "a22"  
25 and "a33" are respectively obtained by subtracting the

product of "k2" by "d23" from the old coefficients "a22" and "a33".

For the first correction, it is assumed that coefficients "a22" and "a33" were respectively 1.

5 Constants "k1" and "k2" are experimentally determined according to frequency of correction, stability, and so on. With this correction, the pixel to be developed by the video signal VD2 gets closer to the scanning line 3 from upon the scanning line 2 and the pixel to  
10 be developed by the video signal VD3 gets closer to the scanning line 2 from upon the scanning line 3. Thus the distance between the scanning lines becomes smaller.

Next the means 102 corrects the distance between  
15 the scanning lines 4 and 1. This example assumes that the quantity of correction "d41" is  $V_{41} - V_a$ . The interference coefficients "a43" and "a12" are respectively obtained by adding the product of "k1" by "d41" to the old coefficients "a43" and "a12." For the  
20 first correction, coefficients "a43" and "a12" are respectively 0. The interference coefficients "a44" and "a11" are respectively obtained by subtracting the product of "k2" by "d41" from the old coefficients "a44" and "a11." For the first correction, it is  
25 assumed that coefficients "a44" and "a11" were

respectively 1.

Constants "k1" and "k2" are experimentally determined according to frequency of correction, stability, and so on. With this correction, the pixel to be developed by the video signal VD4 gets closer to the scanning line 3 from upon the scanning line 4 and the pixel to be developed by the video signal VD1 gets closer to the scanning line 2 from upon the scanning line 1. Thus the distance between the scanning lines becomes greater.

FIG. 14 shows an example of an interference circuit 101 using ROM 1401. In the image recording device according to the present invention, after measurement of surface potentials, the resulting signals (V12, V23, V34, and V41) (illustrated in FIG. 11 (1)) are respectively converted into 4-bit signals by the analog-digital converters 1402 (A-D converters), latched, and fed to the address inputs of ROM 1401. ROM1401 determines the coefficients of the matrix A.

ROM 1401 multiplies said 1-bit video signals VD1, VD2, VD3, and VD4 which are fed to the address inputs of ROM by said matrix A and outputs the resulting 2-bit signals VDd1, VDd2, VDd3, and VDd4 as data. Substantially, ROM 1401 stores the results of calculations of all possible combinations of the

signals (V12, V23, V34, and V41) and the video signals (VD1, VD2, VD3, and VD4) in advance.

The 2-bit signals VDd1, VDd2, VDd3, and VDd4 are fed to the 2-bit FIFO (First-In First-Out) memory 103 and output with delays given by the pixel clocks DCLKd1, DCLKd2, DCLKd3, and DCLKd4.

The details of FIFO 103 will be explained later in the description of positional correction of beam spots in the main scanning direction. The signals VDd 1, VDd2, VDd3, and VDd4 output from FIFO 103 are fed to the pulse modulation circuit 106 and output from there as binary modulated video signals VDe1, VDe2, VDe3, and VDe4.

FIG. 25 shows an example of a pulse modulation circuit 106 of the present invention. Signals VDd1, VDd2, VDd3, and VDd4 are fed to the digital-analog (D-A) converter 2501. The digital-analog (D-A) converter 2501 latches these signals by the pixel clock DCLK1 and converts them into analog signals 2504. When receiving the pixel clock DCLK1, the saw-tooth generator 2502 increases the output voltage linearly to form a saw-tooth wave 2505 until the next pixel clock DCLK1 comes.

The comparator 2503 compares the saw-tooth wave 2505 by the analog signal 2504. The comparator 2503



outputs a binary signal VDel of "1" when the analog signal 2504 is greater than the saw-tooth wave 2505 or a binary signal VDel of "0" when the analog signal 2504 is not greater than the saw-tooth wave 2505.

5        FIG. 26 shows the result of modulation by said pulse modulation circuit 106. It contains a pixel clock DCLK1, an analog signal 2504, a saw-tooth wave 2505, a signal VDel and pixels which are developed actually. In this device example, one pulse is  
10       generated between two consecutive pixel clocks DCLK1 and its width is modulated.

      This is effective when the response ability of the laser light sources 310 are not enough. If the response ability of the laser light sources 310 has  
15       high enough, it is possible to generate two or more pulses and modulate their widths. In such a case, horizontal lines can be recorded smooth. When the laser light source 310 can input analog signals, the analog signal 2504 can be directly output as VDel.

20       With these, the image recording device according to the present invention can form high-quality high-resolution images without irregularity of scanning line pitches (without positional errors of beam spots 1, 2, 3, and 4 in the subsidiary scanning direction).

25       After correcting the positional errors of beam

spots in the subsidiary scanning direction, the image recording device of the present invention corrects the positional errors of beam spots in the main scanning direction.

5       The image recording device of the present invention exposes the test pattern for measuring the positional errors in the main scanning direction spot by spot onto the photosensitive drum 303.

10       The second column of the table of FIG. 16 shows test patterns for measuring positional errors of beam spots in the main scanning direction. This embodiment uses a test pattern for measuring the distance between beam spots 1 and 2. To accomplish this, the exposure optical system 802 exposes beam spots 1 by repeatedly  
15       applying a video signal VD1 of "1000" ("1" for black and "0" for white), beam spots 2 by repeatedly applying a video signal VD2 of "0100," and unexposes the other beam spots 3 and 4 by repeatedly applying video signals VD3 and VD4 of "0000".

20       When this test pattern is recorded on a 1cm-square area of the photosensitive drum surface, the surface potentiometer 803 (see FIG. 8) can measure the mean surface potentials of the patterns. The elliptic areas of test patterns (in the second column of the table of  
25       FIG.16) are exposed areas and their surface potentials

are low. Generally, the surface of the photosensitive drum 303 is uniformly charged to about -600 volts by the charger 801. When the charged photosensitive drum is exposed to a laser beam, the potential of the exposed areas on the charged surface goes down. However the quantity of a voltage drop to the quantity of exposure is apt to be saturated and the quantity of exposure for beam spots is strong enough for saturation.

Therefore the elliptic areas of test patterns (in the second column of the table of FIG. 16) has a saturated potential (-50 volt for this embodiment) which is termed as a residual potential. However, the surface potentiometer 803 does not have an ability to identify potential differences of scanning lines and takes the average of the potentials.

The first column of FIG. 16 shows changes of scanning line pitches: optimum line position B without any deviation, left-deviated line position A (by 20  $\mu\text{m}$ ) and right-deviated line position B (by 20  $\mu\text{m}$ ). The third column of FIG.16 shows their mean surface potentials measured by the surface potentiometer 803. As seen from FIG.16, the mean surface potential negatively increases as the beam spot 2 moves left away from the beam spot 1.

This is dependent upon the ratio of the exposed area whose potential is reduced to -50 volts (elliptic area in the second column of FIG. 16) to the unexposed area whose potential remains at -600 volts. The fourth column of the table in FIG. 16 shows the approximate ratios of the elliptic areas calculated from the test patterns given in the second column of the table. As seen from these ratios, as the beam spot 2 moves left away from beam spot 1, the exposed area becomes smaller and the mean surface voltage will not go low.

The mean surface voltages in the third column of the table of FIG. 16 are examples. Their magnitudes are dependent upon charging and exposing conditions. However, the relationship between distances of beam spots 2 and 1 in the main scanning direction and mean surface potentials which are measured under an identical condition remains unchanged.

In other words, distances of beam spots 2 and 1 in the main scanning direction are always identical as far as mean surface potentials are identical. This characteristic can be used for correction of deviations of beam spot in the main scanning direction.

Although FIG. 16 shows test patterns for measuring the relative distance between beam spots 1 and 2 in the main scanning direction and the result of

measurement of their surface potentials, the similar test patterns can be used for each pair of the other beam spots (2 and 3, 3 and 4, and 4 and 1) and the similar results of measurement of surface potentials can be obtained.

FIG. 17 (1) shows the surface potentials V12, V23, V34, and V41 measured in the execution of a test pattern for measuring relative distances between beam spots 1 and 2, 2 and 3, 3 and 4, and 4 and 1 in the main scanning direction. This result shows that the relative distance between beam spots 2 and 3 is great and that between beam spots 4 and 1 is short.

When a correction is made to make all these surface potentials V12, V23, V34, and V41 identical as shown in Example (2) of FIG. 17, the all relative distances of beam spots become equal to the standard width (42  $\mu$ m) of one pixel. In other words, all beam spots are not deviated in the main scanning direction. Such a correcting procedure is explained below.

FIG. 27 shows an example of means 105 for determining delay time periods according to the present invention. FIG. 27 (1) shows the result of potential measurement which is the same as FIG. 17 (1). The means 105 calculates the difference between each surface potential (V12, V23, V34, and V41) and the



average  $V_a$  ( $= (V_{12} + V_{23} + V_{34} + V_{41}) / 4$ ) and judges whether the relative distance between each pair of beam spots is small or large in the main scanning direction.

5        In this example, as the surface potential  $V_{23}$  is lower than the average voltage  $V_a$ , the beam spot 3 is moved right away from the beam spot 2. Similarly, as the surface potential  $V_{41}$  is higher than the average voltage  $V_a$ , the beam spot 1 is moved left away from  
10       the beam spot 4. For correction of these deviations, the means 105 determines delay time periods as shown in FIG. 27 (2).

      First the means 105 corrects the positional relationship between beam spots 2 and 3 in the main  
15       scanning direction. This example assumes that the quantity of correction " $d_{23}$ " is  $V_a - V_{23}$ . The delay time periods " $t_2$ " and " $t_3$ " are respectively obtained by adding the product of " $k_1$ " by " $d_{23}$ " to the old delay time period " $t_2$ " and subtracting the product  
20       from " $t_3$ ."

      For the first correction, delay time periods " $t_2$ " and " $t_3$ " are respectively 0. The correction constant " $k_1$ " is experimentally determined according to frequency of correction, stability, and so on. This  
25       correction eliminates the unwanted distance between a

pixel developed by the video signal VD2 and a pixel developed by the video signal VD3 in the main scanning direction.

Next the means 105 corrects the positional relationship between beam spots 2 and 3 in the main scanning direction. This example assumes that the quantity of correction "d41" is  $V_{41} - V_a$ . The delay time periods "t4" and "t1" are respectively obtained by subtracting the product of "k1" by "d41" from the old delay time period "t4" and adding the product to "t1." For the first correction, delay time periods "t4" and "t1" are respectively 0.

The correction constant "k1" is experimentally determined according to frequency of correction, stability, and so on. This correction eliminates the unwanted distance between a pixel developed by the video signal VD4 and a pixel developed by the video signal VD1 in the main scanning direction.

Then the means 105 makes the delay time periods positive. As actual delay elements cannot generate negative delay time periods, the means 105 performs a simple operation to make them positive. The means 105 subtracts the minimum delay time period "tm" from each of said delay time periods "t1," "t2," "t3," and "t4." The resulting differences "T1," "T2," "T3," and "T4"

are positive values.

For actual delay elements, the minimum delay times usually are greater than 0. In this case, the delay time periods "T1," "T2," "T3," and "T4" can be made greater by making "tm" smaller. Although the whole image moves by a time period "tm" along the main scanning direction in this operation, this deviation usually is one pixel or less and can be ignored unless the image is corrected during recording.

The resolution of the embodiment of the present invention is 600 dots per inch (dpi) and 1 pixel is 42  $\mu$ m big. The pixels are scanned at a rate of 50 nsec. The delay time periods "T1 = 28," "T2 = 28," "T3 = 8," and "T4 = 8" are set for the result of measurement shown in FIG. 17 (1) for correction. With these delays, the position of the beam spots 1 and 2 are corrected by about 17  $\mu$ m in the main scanning direction.

FIG. 18 shows an example consisting of a means which uses ROM 1801 to determine delay time periods and delay circuits 104. After measurement of surface potentials, the resulting signals (V12, V23, V34, and V41) (illustrated in FIG. 11 (1)) are respectively converted into 4-bit signals by the analog-digital converters 1802 (A-D converters), latched, and fed to the address inputs of ROM 1801.

ROM1801 determines the delay time periods "T1," "T2," "T3," and "T4" by said calculation and outputs them as 4-bit signals respectively to the delay circuits 104. Substantially, ROM 1401 stores the results of calculations of all possible combinations of the signals (V12, V23, V34, and V41) in advance. The means 105 for determining delay time periods consists of delay lines with 16 normal taps and a selector for selecting one of 16 delay signals output from the taps by 4-bit delay time signals "T1," "T2," "T3," and "T4."

This embodiment uses delay circuits 104 each of which can select 8, 12, 16, 20, ..., 68 nsec. With these, the pixel clocks DCLK1, DCLK2, DCLK3, and DCLK4 are delayed respectively by "T1," "T2," "T3," and "T4" into DCLKd1, DCLKd2, DCLKd3, and DCLKd4. The resulting pixel clocks control the output of FIFO 103.

FIG. 28 shows an embodiment of FIFO 103 of the present invention. The write address counter 2801 is cleared to zero by a synchronization signal BD1 and incremented by a pixel clock DCLK1. The video signal VDdi (i = 1, 2, 3, and 4) which is fed in synchronism with the pixel clock DCLK1 is stored in the temporary buffer 2802, then written on an address pointed to by the write address counter 2801 of memory 2803.

On the other hand, the read address counter 2804 is cleared to zero by a synchronization signal BDi and incremented by a pixel clock DCLKdi. As the result, the video signal VDdi which has been stored in the address pointed to by the read address counter 2804 in memory 2803 is set in the temporary output buffer 2805 and output from there in synchronism with the pixel clock DCLKdi.

In FIFO 103, the pixel clock DCLKl to write and DCLKdi to read work completely independently. Therefore, after FIFO 103, the video signals VDe1, VDe2, VDe3, and VDe4 that were in synchronism with the pixel clock DCLKl are in synchronism with the pixel clocks DCLKd1, DCLKd2, DCLKd3, and DCLKd4 for each beam spot whose positional error in the main scanning direction is corrected.

When printed by the engine 205, the recorded image is a high-quality and high-resolution image without jitters which are positional errors of beam spots in the main scanning direction.

The aforesaid explanation does not include any influence by face tilting of the rotary polygon mirror 302. Although the aforesaid control can average the influences of scanning faces and the image quality can be increased, it is also possible to make the control



more accurately by controlling scanning faces individually as this control can be done in real time. Substantially, the same circuit configuration as FIG. 14 is used and the same operation is repeated as many  
5 times as the number of scanning faces. This technique requires less hardware load but its controlling accuracy is low.

For actual uses, the interference circuits 101 as many as the scanning faces are provided and  
10 controlling is switched for each face. This repetitive control can effectively reduces influences by the circumferential dispersion or flaws on the photosensitive drum which cannot be removed by a single controlling, using data of each face which has  
15 been stored in advance. This control sequence is illustrated in FIG. 30. This control can eliminate irregularity of scanning pitches of laser beams on each face.

Now we must consider that scanning lines may be  
20 deviated on scanning faces because of face tilting although the scanning pitches of beams are well controlled on a single face. For example, let's assume that the rotary polygon mirror has four faces for purpose of simplicity. In this example, we can easily  
25 recognize that the same test patterns and control

circuits can be used to determine the quantity of correction by handling four beams (on one face) as one unit and by replacing the above-explained beams by a scanning face.

5        One embodiment of control sequence is illustrated in FIG. 31. First controlling is made on a single scanning face, then made on scanning faces. In the aforesaid explanation, we have discussed about the irregularity in the gray level as an item to be  
10        controlled.

         However, the present and advanced controlling will be more complicated and higher accuracy of controlling is required because it contains low-frequency components which are sensitive to visual  
15        characteristics of persons (the number of beams by the number of scanning faces or the number of beams by the number of scanning faces by a dithering pattern pitch (when considering a dithering pattern pitch)).

         With this, the correcting procedure of the present  
20        invention is completed. Now we can get high-quality and high-resolution images without any positional error of beam spots in main and subsidiary scanning directions.

         This correcting procedure first performs  
25        correction of positional errors in the subsidiary

scanning direction and then correction of positional errors in the main scanning direction. However, this order cannot be reversed because the test pattern for measuring positional errors in the main scanning direction is not available if there exists a positional error in the subsidiary scanning direction although the test pattern for measuring positional errors in the subsidiary scanning direction is available even when there exists a positional error in the main scanning direction. Only one correcting procedure is enough but it is recommended to repeat this correcting procedure a number of times for higher accuracy.

For example, print out some pages after correction, then repeat this correcting procedure once more. You can also correct positional errors due to environmental changes, etc. Further, this correcting procedure simply measures potentials of exposed surfaces on the photosensitive drum and requires no recording medium such as toner and paper because images need not be developed and transferred. Further the engine 205 need not be modified because the surface potentiometers are found in almost all conventional image recording devices.

With this, said control-related explanation is

completed. Next will be explained items on optical system hardware to support the aforesaid controlling.

As for light sources, semiconductor laser arrays will be prevailing judging from their easy

5 installation, compactness, and easy controlling. FIG. 32 shows the structure of an example of a cleaved laser array.

This is a typical laser array and its detailed explanation is omitted. The emitting powers of laser  
10 beams are controlled by currents fed from the p-electrodes 3109 to 3112. In this case, the laser light source must be disposed to satisfy the optical magnification (the ratio of the diameter of a beam spot on the surface of the photosensitive drum to the  
15 diameter of the light emitting point of the laser array). A usual semiconductor laser array has light-emitting points 3113 to 3116 of 5  $\mu\text{m}$  big equally spaced at intervals of 100  $\mu\text{m}$ .

When the semiconductor laser array is designed to  
20 form beam spots of about 50  $\mu\text{m}$  on the surface of the photosensitive drum 303, the light-emitting points of the laser array must be spaced at intervals of about 1 mm considering the optical magnification, fan-out angle of the beam emission. The subsidiary scanning  
25 pitch of 1mm is too large although there is a skip-

scanning technique. Therefore the semiconductor laser array is tilted about 90 degrees as shown in FIG. 33 and arranged so that the scanning line pitch of a preset value may be made on the photosensitive drum.

5        FIG. 33 shows a scanning example of 600 dpi in which the scanning lines are spaced at intervals of 42  $\mu\text{m}$ . In this example, positional errors of beam spots may be generated but they can be eliminated by setting offset times of 1mm, 2mm, and 3mm by the delay  
10        circuits 104 in FIG. 1. The greatest merit of this configuration is that the structural dispersion of beams in the subsidiary scanning direction can be reduced greatly.

15        In other words, the pitch irregularity  $\delta$  of beams in the subsidiary scanning direction (using a semiconductor laser array shown in FIG.32) can be greatly reduced at a rate of  $\delta \tan\theta$  and consequently, the laser arrays can be produced with less manufacturing load.

20        When said semiconductor laser array is used in combination with the controlling according to the present invention, higher controlling can be accomplished. When this controlling is considered differently, the feedback controlling by test patterns  
25        according to this example can be used for initial fine



controlling and further makes its adjustment easier.

For example, as shown in FIG. 34, the monitor PD3301 is placed behind the laser emitting surface of the laser array 3100. In this configuration, the  
5 monitored intensity of a laser beam from the center of the laser array is not equal to the monitored intensity of a laser beam from the end of the laser array because the laser emission angle is great even when the laser beams have the same power. As seen from  
10 the figure, it is ideal to provide a monitor PD3301 for each laser source, but it is substantially impossible judging from the installation technique.

Another technique can be considered to feed back the light quantity in a time-division manner. However  
15 it is extremely difficult to cause an identical percentage of laser beam to be applied to the monitor PD3301. The last possible technique is to judge the efficiency of use of laser beams to the monitor PD3301 by the feedback from the surface potential detector  
20 over the photosensitive drum. As the difference of laser powers is very sensitive to the rise characteristics of the above-mentioned line synchronization sensor, exact controlling is required.

This is very dependent upon performances and  
25 dispositions of the laser array, the monitor PD, the

rotary polygon mirror, the optical scanning lens, and the BD sensor. A method of measuring actual latent images and controlling by feedback or by quantity of exposure is extremely effective as a method of easily making the total system closer to the optimum values.

Next, FIG. 37 shows an embodiment of a sequence of measuring the initial characteristics of the laser array. The purpose of this sequence is to solve problems dependent upon the performance and disposition of each laser source and to perform exact initial setting by contact-exposing test patterns of a non-saturation light quantity (e.g. half of the quantity of exposure) onto the photosensitive drum and feeding back the result for controlling.

It is effective to apply a test pattern repeatedly by changing its light quantity levels and perform feedback control until the influence by the environmental changes (e.g. temperature changes) is eliminated and the values become fixed.

Recently, there have been developed various plane-illumination laser units having small beam fan-out angles and small laser emitting pitches (about 10  $\mu\text{m}$ ) as the laser manufacturing technique improves. The latest laser light source can give a beam spot pitch of about 60  $\mu\text{m}$  (equivalent to 400 dots per inch) on

the surface of a photosensitive drum. With this laser light source, a high-resolution optical system can be accomplished by means of a skip scanning technique without tilting the semiconductor laser array.

5        FIG. 35 shows an example of a skip scanning by a semiconductor laser array having four laser beam emitting points. We can easily guess that this kind of laser light source is applicable to the present invention. Although this kind of laser light source  
10       can be installed more easily than a tilted semiconductor laser array, it has a demerit that the positional errors of laser beam emitting points will directly give an influence to the scanning line pitches.

15       It is assumed that the present correcting method depending upon designing performance is not enough for the future image recording devices which require higher resolutions. Contrarily, the light quantity controlling method capable of adjusting scanning line  
20       pitches in the subsidiary scanning direction according to the present invention is guessed to be extremely effective to increase the image resolution.

      Further, the image resolution is affected by the number of laser beams, the number of faces of the  
25       rotary polygon mirror, and the number of pixels in the

subsidiary scanning direction in a cell on which area half-toning is performed. It is impossible to completely eliminate irregularities in the subsidiary scanning direction by various corrections. The least common multiple of the aforesaid three factors will cause irregularities in images. Judging from the visual transfer function of human, the aforesaid least common multiple must not be a low frequency.

FIG. 36 shows a visual transfer function of human. We hardly recognize images of higher frequencies than 4 line pairs per mm. Therefore, if the aforesaid least common multiple goes over 4 line pairs per mm, the visual transfer function of human does not matter. However, this cannot be ignored when the image has a continuous halftone range. For example, an image recording device having a resolution of 600 dpi (24 lines per mm) and 8 mirror faces may form images of 4 line pairs/mm.

Now returning to the consideration of influences by major factors (the number of laser beams, the number of faces of the rotary polygon mirror, and the number of pixels in the subsidiary scanning direction in a cell on which area half-toning is performed), the resolution is less affected as the least common multiple of these factors becomes smaller.

For example, a rotary polygon mirror of a fast image recording device generally has eight faces considering the scanning angle. Accordingly, using four laser beams and 4 or 8 pixels in the subsidiary scanning direction in a cell on which area half-toning is performed is prevailing. If the rotary polygon mirror has six faces, using 3 or 6 laser beams and 3 or 6 pixels in the subsidiary scanning direction is prevailing.

In other words, it is significant that any other values than the three maximum values are divided by integers without a remainder. In such a case, the maximum is equal to the least common multiple. The number of mirror faces and the least common multiple can be reduced by increasing the number of laser beams.

At the same time, increasing the number of laser beams means that the positional error of a laser beam becomes greater. Also judging from this, the above-explained exposure quantity control is extremely effective. It is needless to say that the method of freely changing scanning positions has a greater degree of freedom in designing than any other methods.

One of irregularity causes that have not been explained may be an irregular scanning speed in the subsidiary scanning direction, that is the irregular



rotational speed of the photosensitive drum. The long-span moving errors caused by an environmental condition (temperature, relative humidity, etc.) can be absorbed by the above-explained methods.

5        However, the short-span moving errors caused by vibrations, etc. are represented by a function of the number of mirror faces and the number of laser beams and can be reduced greatly by the correction control according to the present invention. To make the system  
10        resistant to shocks and vibrations, the basic clock source for driving the mechanism should be provided separately away from the clock source for driving the rotary polygon mirror (to make them out of synchronization).

15        Below will be explained the BD signal generating means of the beam detector 305 which is related to the irregularities in the main scanning direction. The conventional BD signal generating means has digitized analog outputs at a threshold level as shown in FIG.6.

20        In an image recording device using multi-beams, a combination of beam fan-out diameter differences (image surface curve errors and laser specific errors) and laser power differences are great problems. Such problems are logically big loads to the above-  
25        explained method.

To avoid this, a peak hold circuit is effectively used instead of circuit for digitizing the rises of BD signals. The peak-hold circuit rises binary outputs at peak-power timing. Saturation of analog outputs (if  
5 any) can be effectively prevented by a light-quality filter placed before the sensor. Rising the binary output at peak power timing can prevent expansion of laser spots, eliminate power errors, and further improve the accuracy and logical load of the  
10 correcting method.

Referring FIG. 8, FIG. 10, FIG. 16, and FIG. 19, the correcting method will be explained below.

FIG. 8 shows an embodiment of an image recording device of the present invention. Although said  
15 embodiment uses a surface potentiometer 803 (in FIG. 8) as a means to measure the result of exposure of a test pattern, but this embodiment uses an optical density sensor 805 to measure it. The exposure optical system exposes a test pattern for measuring positional  
20 errors onto the surface of the photosensitive drum 303. The electrostatic latent image on the photosensitive drum is developed by means of toner from the developer 804.

The optical density sensor 805 senses the density  
25 of toner on the surface of the photosensitive drum. In

this case, the surface potentiometer 803 and the optical density sensor 805 may be easily covered with toner, which may cause measurement errors. Accordingly it is hard to continue severe controlling. Therefore, it may be recommended to build the surface potentiometer 803 and the optical density sensor 805 in a unit on the developer or toner cartridge and replace them together with the cartridge periodically (at a preset print-out count).

FIG. 19 (1) shows an example of configuration of an optical density sensor. The light-emitting unit 1901 usually is a light emitting diode (LED) having a narrow directivity. The light receiving units 1902 and 1903 are photo diodes or photo transistors PD1 and PD2 having a narrow directivity. The light receiving unit 1902 receives a diffused and reflected light component and the light receiving unit 1903 receives a regular reflected light component.

The positions of these units are determined according to the reflection characteristics of toner and surface of the photosensitive drum 303, the directivities of the light emitting and receiving units, etc. Namely, the units are placed at positions which have the greatest signal changes. As shown in FIG. 19 (2), this embodiment gets an output by

calculating the signals of the light receiving units 1902 and 1903 adequately. Usually, lights from areas of about 1 cm in diameter are measured and averaged.

The "Optical density" fields of FIG. 10 and FIG. 16 show the results of actual measurement. Their units are optical reflection densities. Therefore, "Measure mean surface voltage of photosensitive drum." (2 places) in FIG. 9 can be substituted by "Measure optical density of toner on the photosensitive drum." The other items in the operational flow are the same as those of said embodiment.

Unlike said method of measuring the mean surface potentials of the photosensitive drum, this method (of measuring the mean optical densities of tone on the photosensitive drum) requires toner (to develop test patterns) and wiping away toner from the surface of the photosensitive drum after measurement. This gives a load to the engine 205, but the measurement is very exact. Its reason is explained below.

The developing characteristic (surface potential vs. quantity of attached toner) of the developer 804 has more striking saturation characteristic than the exposure characteristic (quantity of exposure vs. surface potential) of said photosensitive drum 303. Further, the optical characteristic (quantity of

attached toner vs. optical reflection factor) of the optical density sensor 805 also has a saturation characteristic.

5 When the light from the exposed part of the test pattern (see "Test Pattern" fields of FIG. 10 and FIG. 16) is converted into a signal of the optical density sensor 805 through said exposure characteristic, developing characteristic, and optical characteristic, the signal is digitized at a preset threshold level  
10 and has a complete binary characteristics (quantity of exposure vs. optical reflection factor).

The binary characteristics makes the measurement resistant to noises such as density fluctuations. This phenomenon is common in most electronic photographic  
15 processes. The densities of a toner image formed on the photosensitive drum can be easily checked by taking a picture of the toner image by a camera and measuring the densities of the picture image on a film by a microscopic densitometer.

20 Accordingly, the mean optical density values in the "Optical Density" fields of FIG.16 is linearly proportional to the "Ratio of exposed area" values. As the result, this embodiment can perform measurement of positional errors of beam spots which is more accurate  
25 and more resistant to noises than the old embodiment



of measuring the surface potentials on the photosensitive drum.

Referring FIG. 20 and FIG. 21, the scanning line pitches are explained. The purpose of the above-said  
5 embodiment is to make pitches of actual scanning lines equal to the standard scanning line pitch determined by the engine 205. The purpose of this embodiment is to make pitches of actual scanning lines equal to any other scanning line pitch than that determined by the  
10 engine 205.

For example, this image recording device has a resolution of 600 dots per inch which is equivalent to a standard scanning line pitch of 42.3  $\mu\text{m}$ . This  
embodiment changes this scanning line pitch to 52.9  $\mu\text{m}$   
15 (equivalent to a resolution of 480 dots per inch). This scanning lines changed from the standard scanning lines are termed as virtual scanning lines.

FIG. 20 (1) shows how scanning line positions are corrected. The embodiment of an image recording device  
20 of the present invention is a multi-beam laser printer of a resolution of 600 dots per inch using five laser beams. This embodiment assumes that five standard scanning lines 1, 2, 3, 4, and 5 (represented by solid lines) are correctly formed by beam spots 1, 2, 3, 4,  
25 and 5. All these scanning lines are equally spaced at

an interval of  $42.3 \mu\text{m}$ . FIG. 20 (2) shows virtual scanning lines formed at a resolution of 480 dots per inch.

For convenience, a set of four virtual scanning lines are numbered 1, 2, 3, and 4 from the top. The virtual scanning lines are equally spaced at an interval of  $52.9 \mu\text{m}$ . The dotted lines are given at intervals of  $5.3 \mu\text{m}$  to clarify the positional relationship between the standard and virtual scanning lines. Standard lines at a resolution of 600 dots per inch are drawn for every eight dotted lines and virtual lines at a resolution of 480 dots per inch are drawn for every ten lines.

As seen from FIG. 20, the virtual scanning line 1 is between standard scanning lines 1 and 2. To get a virtual scanning line 1, the standard scanning line 1 is moved downward (toward the standard scanning line 2) by  $+15.3 \mu\text{m}$ . This is accomplished by dividing the signal VD1 into VDd1 and VDd2 by the interference circuit 101 of FIG. 1. Substantially, as shown in FIG.13, increase the coefficient "a12" and reduce the coefficient "a11" by that amount in the matrix A (expanded to have elements  $5 \times 5$ ).

Similarly, the virtual scanning line 2 is between standard scanning lines 2 and 3. To get a virtual

scanning line 2, the standard scanning line 2 is moved downward (toward the standard scanning line 3) by +15.9  $\mu\text{m}$ . This is accomplished by dividing the signal VD2 into VDd2 and VDd3 by the interference circuit 101 of FIG.1. Substantially, as shown in FIG.13, increase the coefficient "a23" and reduce the coefficient "a22" by that amount in the matrix A (expanded to have elements  $5 \times 5$ ).

Also similarly, the virtual scanning line 3 is between standard scanning lines 3 and 4. To get a virtual scanning line 3, the standard scanning line 4 is moved upward (toward the standard scanning line 3) by +15.9  $\mu\text{m}$ . This is accomplished by dividing the signal VD4 into VDd3 and VDd4 by the interference circuit 101 of FIG. 1. Substantially, as shown in FIG.13, increase the coefficient "a43" and reduce the coefficient "a44" by that amount in the matrix A (expanded to have elements  $5 \times 5$ ).

Further, the virtual scanning line 4 is between standard scanning lines 4 and 5.

To get a virtual scanning line 4, the standard scanning line 5 is moved upward (toward the standard scanning line 4) by +5.3  $\mu\text{m}$ . This is accomplished by dividing the signal VD5 into VDd4 and VDd5 by the interference circuit 101 of FIG. 1. Substantially, as

shown in FIG.13, increase the coefficient "a54" and reduce the coefficient "a55" by that amount in the matrix A (expanded to have elements  $5 \times 5$ ).

5 In this case, no signal is applied to VD3, but the signal VDd3 has interference light quantity components "a23" and "a43" of signals VD2 and VD4. Therefore, the beam spot on the standard scanning line also illuminates.

FIG. 21 shows another embodiment of an  
10 interference circuit 101 by ROM. ROM receives five video signals VD1, VD2, VD3, VD4, and VD5 corresponding to beam spots 1, 2, 3, 4, and 5 from the printer controller 203 and a RES signal (4 bits in this example) related to a new resolution. The  
15 resolution of 480 dots per inch is commanded by the RES signal properly. Unlike the above-said embodiment, this embodiment can switch resolutions by the RES signal at any time during recording.

In this embodiment (to change resolutions to 480  
20 dots per inch), the video signal VD3 of VD1 to VD5 sent from the printer controller is always off. Substantially only video signals VD1, VD2, VD4, and VD5 are fed to ROM. Substantially, ROM stores the results of calculations (output signals VDd1, VDd2, VDd3, and VDd4) of all possible combinations of the  
25

video signals (VD1, VD2, VD3, and VD4) and the RES signal in advance. Further, coefficients of the matrix A are also determined experimentally in the similar manner as the above-mentioned embodiment.

5        This embodiment can record image data 207 at a resolution of 480 dots per inch directly on a 600-dpi engine 205. Here the resolution in the main scanning direction will not be explained because it is well known that the resolution in the main scanning  
10       direction can be changed simply by changing the frequency of the pixel clock DCLK (in case of a laser printer).

      In comparison to a method of changing resolutions (480 dpi to 600 dpi) of image data 207 by calculation,  
15       this method has various merits such as correct line width, no moire pattern in half-tone images made by dots, and high-quality recorded images. It is also possible to combine this embodiment with an aforesaid embodiment for correcting scanning line pitches by  
20       rewriting data of ROM of FIG. 14, FIG. 16, and FIG. 21.

      Below will be explained the other embodiments referring to drawings.

      FIG. 38 shows a block diagram indicating the operating environment of an image recording device  
25       according to the present invention. The user creates



image data 4004 on the host computer (personal computer) 4001 and sends it to the printer controller 4002.

5 Usually, most image data 4004 is page description data representing the content of a recorded page but part of image data can be raster data that can be directly fed to the laser printer 4003. This embodiment assumes that the most image data 4004 is page description data.

10 When printing starts, the image data 4004 is sent from the host computer 4001 to the printer controller 4002 through a network and the like, read page by page by the printer controller 4002 and expanded into a raster image which is an array of 2-dimensional image data on the bit-map memory.

When creation of a raster image is completed, the printer controller 4002 outputs a print request signal 4005 to the laser printer 4003 to start the printer. In response to a BD (Beam Detection) signal 4008 from  
20 the laser printer 4003, the printer controller 4002 sends print data (print dot size data) 4006 to the laser printer 4003. The laser printer 4003 forms an electrostatic latent image on the photosensitive drum and the like according to the print data 4006,  
25 develops it with toner and transfers the toner image

to a recording medium.

FIG. 39 is a block diagram of a printer controller 4002 of FIG. 38. The printer controller 4002 consists of an RIP (Raster Image) expansion unit 4009, a beam synchronizer 4030, a pulse-width modulator 4010 (pulse generation block: multi-leveling unit) for laser driving signals, a signal corrector 4011 (multi-level correcting unit) for laser driving signals, and a printer interface block 4012.

The RIP expansion unit 4009 receives image data 4004 which is page description data from the host computer 4001, expands it into a raster image and outputs it as multi-level image data 4013 which can be represented with half tones.

The beam synchronizer 4030 receives multi-level image data 4013 and outputs multi-level image data 4031 to the pulse-width modulator 4010 in synchronism with the BD signals 4008 for laser beams.

The pulse-width modulator 4010 converts multi-level image data 4031 into multi-level print data (dot size data) 4006 by modulating the widths of binary pulses (having high and low levels) according to dot sizes (beam sizes) and outputs the print data 4006 to the laser printer 4003. The pulse-width modulator 4010 requires as many pulse generators (pulse-width

modulating blocks) as the number of laser beams which the laser printer 4003 uses. Accordingly, there should be as many print data lines as the number of laser beams.

5       The printer interface 4012 sends a print request signal 4005 to the laser printer 4003. It also receives BD signals 4008 and generates pixel clocks 4015.

10       The printer interface 4012 outputs a beam error correction command 4017 to the signal corrector to correct the dispersion of image forming laser beams when the correction mode is set.

This beam error correction will be explained below referring to FIG. 40.

15       FIG. 40 is a block diagram of a printer controller 4002 of FIG. 39 which receives image data of four laser beams

20       The pulse-width modulator 4010 contains as many pulse-width modulating blocks (hereinafter abbreviated as PWM) as laser beams used for scanning. They are a first PWM 4048, a second PWM 4049, a third PWM 4050, and a fourth PWM 4051. These pulse-width modulating blocks respectively modulate the pulse-widths of multi-level image data 4013-1 through 4013-4 and  
25       output the resulting print data (laser driving

signals) 4006-1 through 4006-4.

When receiving the aforesaid Dispersion Correct command 4017 is output from the printer interface 4012, PWM4048 through PWM4051 outputs laser driving signals 4014-1 through 4014-4 for monitoring on the basis of identical image data (monitoring image data). These monitoring laser driving signals 4014-1 through 4014-4 are equivalent to a kind of print data 4006-1 through 4006-4 and used to know the dispersion in the result of pulse-width modulation. In this point, this kind of print data is different from the normal print data.

The laser driving signals 4014-1 through 4014-4 for monitoring are fed into the laser driving circuits (LD) 4040 through 4043 and into the corrector 4011. The corrector 4011 calculates the dispersion in the pulse-width modulation of the laser driving signals 4014-1 through 4014-4 and corrects the laser driving signals 4006-1 through 4006-4 (to be used for image generation) according to this dispersion in pulse-width modulation.

The print data (laser driving signals) 4006-1 through 4006-4 and the light-quantity correction data 4007-1 through 4007-4 which is the output of the corrector 4011 are respectively output to the LD drivers 4040 through 4043 to supply currents I1

through I4 respectively to LD light sources (laser light sources) 4044 through 4047. The LD light sources 4044 through 4047 illuminate at intensities determined by the driving current I1 through I4.

5       As for the relationship of inputs to the LD drivers LD4040 through 4043 (the laser driving signals 4006-1 through 4006-4 and the light-quantity correction data 4007-1 through 4007-4) and outputs from the LD drivers LD4040 through 4043 (the currents  
10       I1 through I4 to the LD light sources 4044 through 4047), the light-quantity correction data 4007-1 through 4007-4 controls the magnitudes of currents I1 through I4 (peak values of pulse currents) to be supplied to the LD light sources 4044 through 4047.  
15       The print data 4006-1 through 4006-4 determines the continuity periods (pulse widths) of currents I1 through I4 supplied to the LD light sources 4044 through 4047.

FIG. 41 shows a block diagram of the corrector  
20       4011 of FIG. 40.

The corrector 4011 consists of a target value setting block 4020, a minimum value detecting block 4029, a subtracting block 4021, and a light-quantity data converting block 4022.

25       The target value setting block 4020 selects one of



monitoring laser driving signals (pulses) 4014-1  
through 4014-4 sent from PWM4048 through PWM4051 in  
the pulse-width modulator 4010 as a reference value  
used for calculation of dispersions in the pulse-width  
5 modulation of these driving signals and outputs it as  
a target modulation value (reference pulse-width  
modulation value) 4027 to the subtraction block 4021.  
Although this example uses a laser driving signal  
having the greatest pulse width among signals 4014-1  
10 through 4014-4 as a target value, the user can select  
a laser driving signal having any pulse width.

The subtraction block 4021 takes a pulse-width  
difference between the target value and each  
monitoring laser driving signal (4014-1 through 4014-  
15 4) and outputs the result (4023-1 to 4023-4) to the  
light-quantity correction data converter.

The minimum value detection block 4029 detects a  
monitoring laser driving signal having a minimum pulse  
width among the signals (4014-1 through 4014-4) sent  
20 from the pulse-width modulator 4010 and outputs it as  
a minimum reference modulation value 4028. This value  
4028 is used as a base of a triangular wave generation  
signal for generation of light-quantity correction  
data (to be explained in FIG. 49).

25 The light-quantity correction data converter 4022

receives the results of subtraction 4023-1 through 4023-4 and the minimum reference modulation value 4028 and converts them into light-quantity correction data 4007-1 through 4007-4.

5       Referring to FIG. 42, the operation of the corrector 4011 (for correcting the laser driving signals) will be explained below.

FIG. 42 shows an operational flow of the corrector 4011 (for correcting the laser driving signals).

10       When the printer interface 4012 (illustrated in FIG. 40) issues a Dispersion Correct command 4017 (in Dispersion Correct mode), the RIP (Raster Image) expansion unit 4009 outputs identical image data for monitoring to each PWM (4048 through 4051) in the pulse-width modulator 4010.

15       The corrector 4011 fetches pulse-width modulation values (sometimes assigned codes 4014-1 through 4014-4 for explanation) of the laser driving signals 4014-1 through 4014-4 based on said monitoring image data which is output from the PWMs in the pulse-width modulator 4010.

20       Next the target value setting block 4020 selects one of monitoring pulse-width modulation values 4014-1 through 4014-4 as a target value, takes a pulse-width difference between the target value 4027 and each

25

pulse-width modulation value 4014-1 through 4014-4,  
then outputs light-quantity correction data 4007-1  
through 4007-4 corresponding to the result of  
subtraction. The result of subtractions represents the  
5 dispersion of pulse widths created by PWMs (4048 to  
4051) in the pulse-width modulator 40101. This  
dispersion is corrected by the light-quantity  
correction data 4007-1 through 4007-4, which equalizes  
the light power energy (for print dots) that the LD  
10 light sources 4044 through 4047 emit.

Referring to FIG. 43, the above-explained  
operation for equalizing the light power energy will  
be explained in detail.

FIG. 43 shows the relationship of driving currents  
15 (modulation currents) supplied to the LD light sources  
4044 to 4047 (illustrated in FIG. 43), their  
modulation pulse widths (pulse-width modulation  
values), and sizes of dots printed in the main  
scanning direction. This example takes two light  
20 sources 4044 and 4045 among four LD light sources 4044  
to 4047.

This example assumes that identical multi-level  
image data 4013-1 and 4013-2 is fed to PWM4048 and  
PWM4049 (illustrated in FIG. 40) and the outputs  
25 (laser driving signals 4014-1 and 4014-2) from PWM4048

and PWM4049 have different pulse widths "pw1" and "pw2" (although they must be identical). As the result, before correction, a driving current (modulation current) as shown in FIG. 43 (b) is fed to the LD light source 4044 and a driving current (modulation current) as shown in FIG. 43 (d) is fed to the LD light source 4045. An adjustment has been made in advance to set the amplitudes (peak values) of the driving currents of the light sources 4044 and 4045 to I02.

As the amplitudes I02 (peak values) of the driving currents of the light sources 4044 and 4045 are identical, the LD light sources 4044 and 4045 have different light emission energies if their pulse widths are not equal (having a pulse difference  $\Delta t = pw2 - pw1$ ). Consequently, the print dots have different sizes (dot size difference  $\Delta w = w2 - w1$ ).

To correct the dot size difference  $\Delta t$ , namely to correct the print dot size of the LD light source 4044 to "w2" in FIG. 43, the amplitude of the driving current of the LD light source 4044 is increased to I01. When the amplitude of the driving current is increased to I01, the characteristics curve of modulation pulse widths vs. print dot sizes moves as indicated by a dotted curve in FIG.43. Even when the

modulation pulse width is smaller by  $\Delta t$ , the print dot size of the LD light source 4044 becomes  $w_2$ .

FIG. 44 shows a circuit diagram of the target value setting block 4020 of FIG. 41. The target value setting block 4020 consists of inverters 4061 to 4064, latches 4065 to 4068, composite gates 4069 to 4072, and an OR gate 4073. In the circuit of FIG. 44, the maximum pulse width of the monitoring laser driving signals 4014-1 to 4014-4 is selected as a target modulation value 4027.

Referring to FIG. 45, the operation of the target value setting block 4020 of FIG. 44 is explained below.

FIG. 45 shows waveforms of signals of the target value setting block 4020 of FIG. 44.

When identical image data SD is fed as multi-level image data (4013-1 through 4013-4) to PWM4048 through PWM4051 (as shown in (a) of FIG. 45), the monitoring laser driving signals (pulse-width modulation values) 4014-1 through 4014-4 are output as shown in (b) through (e).

Here, the pulse widths of (b) to (e) are named  $pw_1$  to  $pw_4$  and their relationship is expressed by  $pw_3 < pw_1 < pw_2 < pw_4$ .

The output of the latch 4065 (f) is  $Q_0 = 1$  (least significant bit),  $Q_1 = 0$ , and  $Q_2 = 1$  (most significant



bit) as the monitoring driving signals (pulse width modulation values) 4014-2 to 4014-4 are sampled at the fall of the first monitoring laser driving signal (pulse width modulation value). This output value  
5 "101" is equivalent to "5" in decimal.

Similarly, the output values of latches 4066 (g) through 4068 (i) are respectively "4," "5," and "6" in decimal. When the output of a latch has a value of "0" in decimal, that is when Q0 through Q2 are all zeros,  
10 the output of a composite gate that entered this code "0" is determined as a target modulation value 4027. Accordingly, in FIG.45, the target pulse modulation value 4027 is the input of the composite gate 4072 to which the output of the latch 4068 is connected, that  
15 is, the monitoring laser driving signal 4014-4 having a pulse width pw4.

FIG. 46 shows a circuit diagram of the subtraction block 4021 of FIG. 41. Elements 4100 to 4103 are exclusive OR gates.

20 Referring to FIG. 47, the operation of the subtraction block 4021 of FIG. 46 will be explained below.

When identical image data SD is fed as multi-level image data (4013-1 through 4013-4) to PWM4048 through  
25 PWM4051 (as shown in (a) of FIG. 45), the monitoring

laser driving signals (pulse-width modulation values) 4014-1 through 4014-4 are output as shown in (b) through (e). Here, the pulse widths of (b) to (e) are named pw1 to pw4 and their relationship is expressed by  $pw3 < pw1 < pw2 < pw4$ .

The target modulation value 4027 that the target value setting block 4020 outputs (illustrated in FIG. 41) is as shown b (f). Exclusive OR of the target modulation value 4027 (f) and respective pulse width modulation values 4014-1 (b) through 4014-4 (e) are the differential pulse widths as shown by the subtraction values 4023-1 (g) to 4023-4 (j).

FIG. 48 shows a block diagram of the light-quantity correction data converting block 4022 in the corrector 4011 of FIG. 41. This block 4022 consists of triangular wave generators 4080-1 through 4080-4, AND gates 4080 through 4084, sampling switches 4085 through 4088, hold capacitors 4089 through 4092, OP amplifiers 4093 through 4096, and diodes 4115 through 4118.

Referring FIG. 49, the operation of the light-quantity correction data converting block 4022 of FIG.48 will be explained below.

When receiving a Dispersion Correct command 4017 from the printer interface 4012 of FIG.40, the AND

gates 4080 through 4084 in the light-quantity  
correction data converting block 4022 generate  
sampling gate signals 4111 (j) through 4114 (m) from  
the results of subtraction 4023-1 (a) through 4023-4  
5 (d) sent from the subtraction block 4021 of FIG.41.

The triangular wave generators 4080-1 through  
4080-4 generate triangular waves 4110-1 through 4110-4  
at the rises of subtraction values 4023-1 through  
4023-4 periodically at intervals of the minimum  
10 reference modulation value 4028 (e).

The sampling switches 4085 through 4088 send the  
triangular signals 4110-1 through 4110-4 to the hold  
capacitors 4089 through 4092 to charge thereof by the  
sampling gate signals 4111 (j) through 4114 (m). In  
15 other words, the sampling switches 4085 through 4088  
allow triangular signals 4110-1 through 4110-4 to pass  
while the sampling gate signals 4111 through 4114 are  
high.

The charge voltages of the hold capacitors 4089  
20 through 4092 are impedance-converted into light-  
quantity correction data 4007-1 (n) through 4007-4 (q).  
The correction values by the light-quantity correction  
data 4007-1 (n) through 4007-4 (q) are respectively V1,  
V2, V3, and 0 in that order.

25 In this way, the magnitudes of the results of

subtraction, that is, the magnitudes of differences of pulse widths between the monitoring driving signals 4014-1 through 4014-4 and the target modulation value 4027 are added to the light-quantity correction data 4007-1 through 4007-4, that is, the amplitudes (peak values) of the laser driving signals 4006-1 to 4006-4 and converted into the magnitudes of light-quantity correction voltages.

FIG. 50 shows a block diagram of the minimum value detecting block 4029 of FIG. 41. The minimum value detecting block consists of inverters 4161 through 4164, latches 4165 through 4168, AND gates 4169 through 4172, and an OR gate 4173.

The operation of detecting a minimum modulation value 4028 among pulse modulation values of the monitoring driving signals 4014-1 through 4014-4 is not explained here because it is the same as that of detecting a target modulation value 4027 in FIG.44.

FIG. 51 shows a block diagram of a pulse-width modulation block PWM4048 of FIG. 40. (The other pulse-width modulation blocks PWM4049 through PWM4051 have the same circuit configuration.) PWM4048 consists of a reference clock generator 4213, a delay clock generator 4201, a delay time measuring block 4202, a delay clock selector 4203, a pulse generator 4204, and

a pulse selector 4205.

Referring to FIG. 52, the operation of PWM4048 of FIG. 51 will be explained below.

The reference clock 4215 ((a) in FIG. 52) is  
5 obtained by dividing the synchronization clock (pixel clock 4015-1) of one pixel by 2. Namely, multi-level image data 4013-1 ((y) in FIG. 52) is input in synchronism with a pixel clock 4015-1 ((x) in FIG. 52).

The delay clock generator 4201 generates a  
10 plurality of delay clocks 4207 having different delay time periods ((b) to (i) of FIG. 52). FIG. 52 shows eight odd-numbered delay clocks (4207-1, 4207-3, 4207-5, ...) among 16 delay clocks that the delay clock generator 4201 generates. "t1" to "t8" are delay time  
15 periods of the eight delay clocks 4207 ((b) to (i)) relative to the reference clock 4215.

The delay time measuring block 4202 measures delay time periods of delay clocks 4207 by the input of a delay time measuring signal periodically or non-  
20 periodically such as at the startup of the device or just before image formation. Namely, the delay time measuring block 4202 selects a delay clock 4207 to get a delay time equivalent to time "t0" of one pixel at the rise (time T1) of reference clock 4215 as a  
25 sampling clock 4234.



In the example, the delay time measuring block 4202 detects a delay clock 4207-11 ( $t_6$ ) and a delay clock 4207-13 ( $t_7$ ) which change their signal states (from "0" to "1") just before or after time  $T_1$ . With this, the delay time measuring block 4202 judges that the delay clock 4207-11 ( $t_6$ ) is a delay clock to get a delay time equivalent to " $t_0$ " and outputs "11" (in decimal) as a delay time measuring value 4208.

The delay clock selector 4203 selects a desired number of delay clocks (among 16 delay clocks 4207 generated) which are within the delay time measurement value 4208. This number of delay clocks is determined according to the maximum tones (resolution) of the input image information or half-tones required by output images.

The example illustrated in the drawing selects and outputs six delay clocks 4209 from the odd-numbered buffer gates among delay clocks 4207-1 through 4207-11 which are in the delay time measurement value 4208 so that the differences of pulse widths of the generated pulses 4210 may be approximately equal to each other (strictly different judging from the characteristics of said buffer gates). To select delay clocks 4209, the user can select so that the ratio of pulse widths of the generated pulses 4210 may be constant in

addition to the above method of selection.

The pulse generator 4204 performs logical operations on the reference clock 4215 and the six selected delay clocks 4209 and generates six pulse signals 4210 ((j) to (o) in FIG. 52)).

The pulse selector 4205 receives multi-level (8-level) image data 4013-1, selects one of the six generated pulse signals, an all-white pulse signal (of all zeros) and an all-black pulse signal (of all ones) and outputs it as print data 4006-1 which is modulated (pulse-width modulated) along the time base.

In FIG. 52, as the multi-level image data 4013-1 ((y) in FIG. 52) is "2" (in decimal) during a time period (T0 to T1), the pulse selector 4205 outputs a generated pulse 4210-2 ((k) in FIG. 52). The signal becomes print data 4006-1 ((s) in FIG. 52). Similarly as the multi-level image data 4013-1 ((y) in FIG. 52) is "5" (in decimal) during a time period (T1 to T2), the pulse selector 4205 outputs a generated pulse 4210-5 ((n) in FIG. 52). The signal becomes print data 4006-1.

This embodiment can obtain a dispersion of laser drive signals (pulse width modulation values) corresponding to multi-level image data in a multi-beam system from the dispersion of pulse-width

modulation values of the monitoring laser driving  
signals which a plurality of PWM4048 through PWM4051  
output by a Dispersion Correct signal and can generate  
light-quantity correction data to correct the  
5 dispersion.

With this, the energies of laser beams for print  
dots become equal to each other and the dispersion of  
print dot sizes is eliminated according to image data.  
Consequently, high-quality multi-level images can be  
10 recorded in a multi-beam system.

Although said embodiment eliminates the dispersion  
in pulse-width modulation of the laser driving signals  
in a multi-beam image recording system by level  
correction of pulse peak values of the laser driving  
15 signals, the user can correct the dispersion of pulse-  
width modulation values by equalizing the pulse widths.

Referring to FIG.53 to FIG.60, will be explained  
an embodiment for correcting the dispersion of pulse-  
width modulation values of laser beams by correction  
20 of pulse widths

FIG. 53 shows a block diagram of the printer  
controller 4002 of FIG. 38. The numbers and symbols in  
FIG. 53 to FIG. 60 are the same as those in FIG.38 to  
FIG.52.

25 The difference between FIG. 53 and FIG. 39 is in

that the light-quantity correction data (correction pulse widths) output from the laser driving signal corrector 4301 (substitution for the laser driving signal corrector 4011 of FIG.39) is fed to the pulse-width modulator (multi-leveling unit) 4300.

The pulse-width modulator 4300 is controlled by the light-quantity correction data which is output from the corrector 4301 so as to correct the dispersion of pulse widths and converts the multi-level image data 4013 into print data (laser driving signal) 4006 by pulse-width modulation. This correction is done to equalize pulse widths.

To know the dispersion in pulse-width modulation of print data 4006 (laser driving signals) which are output from PWMs in the pulse-width modulator 4300, the corrector 4301 fetches a plurality of monitoring pulse-width modulation values 4014 (monitoring laser driving signals) and converts them into a plurality of light-quantity correction data 4302 (pulse-width correction data).

FIG. 54 shows the block diagram of the printer controller 4310 of FIG. 53 using four laser beams.

The pulse-width modulation 4300 has as many PWMs as the laser beams. They are the first PWM 4303, the second PWM 4304, the third PWM 4305, and the fourth

PWM 4306. The PWM4303 through PWM4306 respectively convert multi-level image data (4013-1 through 4013-4) into print data (laser driving signals 4006-1 through 4006-4).

5       The monitoring pulse-width modulation values (monitoring laser driving signals) 4014-1 through 4014-4 which are sent to the corrector 4301 are functionally the same as print data 4006-1 to 4006-4 but used for monitoring to get the dispersion of pulse  
10 widths.

Print data 4006-1 through 4006-4 are sent to the corrector 4301 and at the same time to the LD drivers 4040 through 4043. The light-quantity correction data 4302-1 through 4302-4 output from the corrector 4301  
15 are respectively sent to PWM4303 through PWM4306.

FIG. 55 shows a functional block diagram of the corrector 4301 of FIG. 54. The corrector 4301 consists of a target value detecting block 4020, a subtracting block 4021, and a light-quantity data converting block  
20 4400.

The target value detecting block 4020 and the subtracting block 4021 are functionally the same as those of FIG. 41.

The light-quantity correction data converter 4400  
25 converts the fine clock 4430 and the results of



subtraction 4023-1 through 4023-4 into light-quantity correction data 4302-1 through 4302-4 by a Dispersion Correct command 4017.

FIG. 56 shows a functional circuit block diagram of the light-quantity correction data converter 4400 of FIG. 55. The light-quantity correction data converter 4400 consists of four light-quantity correction data converting blocks 4401 through 4404. All of these blocks 4401 through 4404 are of the same configuration.

Each light-quantity correction data converting block consists of a counter 4435, a latch 4450, an AND gate, and an inverter 4441.

Referring to FIG. 57, the operation of the light-quantity correction data converter of FIG. 56 will be explained below. The explanation below takes the light-quantity correction data converting block 4401 as an example.

When receiving a Dispersion Correct command 4017 from the printer interface of FIG. 40, the AND gate 4443 in the light-quantity correction data converting block 4401 creates a Count Enable signal 4444 from the results of subtraction 4023-1 (g) sent from the subtracting block. The counter 4435 counts the fine clocks 4430-1 while the Count Enable signal 4444 is

"1" using the target modulation value 4027 as a Clear signal and outputs the count value 4440. The count value 4451 is equivalent to light-quantity correction data 4302-1 of FIG. 54.

5        In this way, the magnitude of the result of subtraction, that is, a difference between the target modulation value 4027 and the pulse width of a monitoring laser driving signal (4014-1 through 4014-4) is converted into the light-quantity correction data, that is, the magnitude of a light-quantity correction time (count of correction pulse widths).

10        The other light-quantity correction data converting blocks 4402 through 4404 perform the same function.

15        FIG. 58 shows a functional block diagram of PWM4303 which is one of the components of the pulse-width modulator 4030 of FIG. 54. FIG. 58 has a delay time selecting block 4420, a fine clock generating block 4460, and an inverter 4465 in addition to FIG.41.

20        FIG.59 shows a functional block diagram of the delay time selecting block 4420. It consists of buffer gates 4471 through 4480 and a selector 4495.

Referring to FIG. 60, the operation of PWM4303 of FIG. 58 will be explained below.

25        FIG. 60 shows the waveforms of operations of

PWM4303 of FIG. 58 and the difference between FIG. 60 and FIG. 52 is that the inversion reference clock 4466 (p) and the correction reference clock 4470 (q) are added and that the generation pulses 4210 (j) to (o) have different pulse widths.

The inverter 4465 inverts the reference clock 4215 (a) into an inverted reference clock 4466 (p). The delay time selecting block 4420 delays the inversion reference clock 4466 (p) by a time period "t10" according to the light-quantity correction data 4302 and generates a correction reference clock 4470.

This function is executed by the selector 4495 of FIG.59. The pulse generator 4204 creates generation pulses 4210 (j) to (o) from the correction reference clock 4470 and the selection delay clock 4209. As the time difference "t11" between the reference clock 4215 (a) and the correction reference clock 4470 (q) is equivalent to the result of subtraction 4023-1 (g) of FIG.57, the generated pulse has the pulse width increased by "t11" of FIG.60 by this correction.

This embodiment also gets a dispersion in the laser driving signals (pulse-width modulation values) according to multi-level image data in the multi-beam system and generates light-quantity correction data (pulse-width correction values) to correct this

dispersion. With this, power energies of beams for  
print dots are equalized and consequently the sizes of  
print dots are corrected and formed according to the  
image data. Thus high-quality multi-level images can  
5 be obtained in the multi-beam image recording system.

The other embodiment of the present invention is  
illustrated in FIG. 61 and FIG. 62.

FIG. 62 shows the details of the pulse-width  
modulation device 4010 and the laser printer 4003 of  
10 FIG. 61. This example uses four laser beams to scan.

In FIG. 61, the printer controller 4002 consists  
of an RIP expansion unit 4009, a correction data  
generator 5000, a beam synchronizer 4030, a pulse-  
width modulator 4010, a signal corrector 4011, an  
15 image clock selector 5001, a Dispersion Correct  
command generator 5002 and a printer interface 4012.

The RIP expansion unit 4009 receives image data D1  
which is page description data from the host computer  
4001, expands it page by page into a raster image  
20 which is a 2-dimensional image data array and outputs  
it as multi-level image data D2 which can be expressed  
with half tones to the beam synchronizer 4030.

The beam synchronizer 4030 synchronizes the multi-  
level image data D2 with the beam detection signals BD  
25 (BD-1 through BD-4) of the four laser beams and

outputs the resulting signals (multi-level image data D3-1 through D3-4) to the pulse-width modulation device 4010.

5 The pulse-width modulator 4010 modulates the pulse-widths of the image data D3-1 through D3-4 and outputs the resulting pulses as print data D4-1 through D4-4 to the laser printer 4003. The pulse-width modulator 4010 requires as many pulse generators (pulse-width modulating blocks 4048 through 4051) as  
10 the number of laser beams which the laser printer 4003 uses.

When receiving a Dispersion Correct command BC, the corrector 4011 gets light-quantity correction data (pulse width correction values) of PWM4048 through  
15 PWM4051 (as explained later) and outputs the resulting signals to the pulse-width modulator 4010.

When receiving a Dispersion Correct command BC, the image clock selector 5001 selects one of image clocks PCK1 through PCK4 sent from the printer  
20 interface 4012 and outputs the resulting signals as the selected image clocks SPCK to the beam synchronizer 4030 and to the pulse-width modulator 4010.

The Dispersion Correct command generator 5002  
25 outputs a Dispersion Correct command BC when the



device is powered on or when a Dispersion Correct command requesting signal BCREQ is entered from the outside.

5 The printer interface 4012 sends a print request signal PREQ to the laser printer 4003. Simultaneously when receiving a beam detection signal BD, the printer interface 4012 isolates beam synchronization signals BD-1 through BD-4 from the beam detection signal BD and generates image clocks PCK in synchronism with the  
10 beam synchronization signals BD-1 through BD-4.

The laser printer 4003 receives the modulated print data D4-1 to D4-4 from the pulse-width modulator 4010 (as illustrated in FIG.62) and supplies driving currents I1 through I4 to the laser diodes LD 4044  
15 through 4047.

FIG. 63 shows a functional block diagram of PWM4048.

In FIG. 63, PWM4048 consists of a reference clock generator 4213, a delay clock generator 4201, a delay  
20 time measuring block 4202, a delay clock selector 4203, a pulse generator 4204, a pulse selector 4205 and a fine clock generator 4430.

The reference clock generator 4213 receives image clock PCK-1 and generates a reference clock SCK.

25 The delay clock generator 4201 receives the

reference clock SCK and generates a plurality of delay clocks DCK having different delay times.

When receiving a Measure Delay Time command signal MES, the delay time measuring block 4202 measures a delay time of each delay clock DCK periodically or non-periodically when the device starts up or just before image formation.

The delay clock selector 4203 generates a selected delay clock SDCK depending upon the result of measurement DLT from the delay clocks DCK.

The pulse generator 4204 performs logical operations on the reference clock and a plurality of selected delay clocks SDCK and generates a plurality of pulses GPW.

The pulse selector 4205 receives multi-level image data D3-1, selects one of a plurality of generated pulses GPW, an all-white pulse signal (of all zeros) and an all-black pulse signal (of all ones) and outputs it as print data APW which is modulated (pulse-width modulated) along the time base.

The pulse-width adjuster 5003 consists of ten serially-connected buffer gates (delay elements) 4471 through 4480 as illustrated in FIG.64. The pulse-width adjuster 5003 selects one of outputs APW-1 through APW-10 from the delay elements 4471 through 4480

according to the light-quantity correction PC-1,  
changes the pulse width of the print data APW, and  
generates print data D4-1.

FIG. 65 shows another embodiment of the corrector  
5 4011.

In FIG. 65, the corrector 4011 consists of a  
target value setting block 4020, a subtracting block  
4021, and a light-quantity data converting block 4400.

The target value setting block 4020 selects (sets),  
10 as a reference pulse width, one of print data D4-1  
through D4-4 sent from PWM4303 through PWM4306 in the  
pulse-width modulator 4010 and outputs it as a target  
modulation value TPW to the subtraction block 4021 and  
to the light-quantity correction data converting block  
15 4400. Although this example sets print data having the  
greatest pulse width among print data D4-1 through D4-  
4 as a target value, the user can select print data  
having any pulse width.

The subtraction block 4021 takes a pulse-width  
20 difference between the target modulation value and  
print data D4-1 through D4-4 and outputs the result  
(DPW-1 through DPW-4) to the light-quantity correction  
data converter.

Upon receipt of a Dispersion Correct command BC,  
25 the light-quantity correction data converter 4400

converts the results of subtraction DPW-1 through DPW-4 into light-quantity correction data PC-1 through PC-4.

5 In this way, the corrector 4011 fetches print data D4-1 through D4-4 from PWM4303 through PWM4306 in the pulse-width modulator 4010 and gets a plurality of light-quantity correction data PC-1 through PC-4 (pulse-width correction data).

10 FIG. 66 shows the block diagram of the pixel clock selector 5001.

The pixel clock selector 5001 consists of four selectors 4495-1 through 4495-4. During normal printing, the pixel clock selector 5001 receives pixel clocks PCK-1 through PCK-4 sent from the printer interface 4012 and outputs the selected pixel clocks SPCK-1 through SPCK-4. Upon receipt of a Dispersion Correct command BC, the selectors 4495-1 through 4495-4 respectively select pixel clocks PCK-1 and outputs the selected pixel clocks SPCK-1 through SPCK-4 (= PCK-1).

15  
20

Then the operation will be explained below.

First signal operations for normal printing will be explained referring to FIG. 67.

The image data D1 created by the host computer 25 4001 is sent to the RIP expansion unit 4009 through a

network or the like.

The RIP expansion unit 4009 receives image data D1 which is page description data, expands it page by page into a raster image which is an array of 2-dimensional image data and stores it as multi-level image data D2 which can be expressed with half-tones. When the multi-level image data D2 is stored in the RIP expansion unit 4009, the printer interface 4012 sends a print-request signal PREQ to the laser printer. When receiving this signal PREQ, the laser printer 4003 outputs a beam detection signal BD (illustrated in FIG. 67 (a)).

When receiving a beam detection signal BD, the printer interface 4012 separates beam detection signals BD-1 through BD-4 as illustrated in FIG. 67 (b), (e), (h), and (k), outputs the signals and generates pixel clocks PCK-1 through PCK-4 (illustrated in FIG. 67 (c), (f), (i), and (l) of FIG. 67) in synchronism with the beam detection signals BD-1 through BD-4.

FIG. 67 shows the relationship of beam detection signals BD-1 through BD-4 of the laser printer 4003, image data D4-1 through D4-4 from the pulse-width modulator 4010, and pixel clocks PCK-1 through PCK-4.

Substantially, the printer interface 4012



generates the first pixel clock PCK-1 with a delay "t" after the first beam detection signal BD-1 which is separated from the beam detection signal BD and generates the first image data D4-1 in synchronism with the first pixel clock PCK-1.

Similarly, the printer interface 4012 generates the second image data D4-2 in synchronism with the second beam detection signal BD-2, the third image data D4-3 in synchronism with the third beam detection signal BD-3, and the fourth image data D4-4 in synchronism with the fourth beam detection signal BD-4.

The synchronism of beam detection signals BD-1 through BD-4 with image data D4-1 through D4-4 in the above explanation assumes that the delay "t" can be ignored substantially.

Usually during normal printing, the Dispersion Correct command BC of the Dispersion Correct command block 6 is at level "0" and the pixel clock selector 5001 outputs pixel clocks PCK-1 through PCK-4 in synchronism with the beam detection signals BD-1 through BD-4 as the selected pixel clocks SPCK-1 through SPCK-4.

The beam synchronizer 4030 receives multi-level image data D2 from the RIP expansion unit 4009, causes the image data to be in synchronism with beam

detection signals BD-1 through BD-4 by the selected pixel clocks SPCK-1 through SPCK-4, and outputs the resulting signals (multi-level image signals D3-1 through D3-4) to the pulse-width modulator 4010.

5       As the pulse-width dispersion is corrected by the corrector 4011, the pulse-width modulator 4010 converts the multi-level image data D3-1 through D3-4 into the pulse-width-modulated print data D4-1 through D4-4 and outputs the resulting signals to the laser  
10       printer 4003. With the print data D4-1 through D4-4 without dispersion in pulse-widths, the laser printer 4003 can print with uniform print dot sizes.

Referring to FIG. 68 and FIG. 69, will be explained a method of correcting the pulse-width  
15       dispersion of the pulse-width modulator 4010.

For correction of a pulse-width dispersion, the Dispersion Correct command block 5002 submits a Dispersion Correct command BC of "1." The Dispersion Correct command generator 5002 outputs a Dispersion  
20       Correct command BC when the device is powered on or when a Dispersion Correct command requesting signal BCREQ is entered from the outside.

When the Dispersion Correct command BC is fed to the laser printer, the laser printer 4003 sends a beam  
25       detection signal BD to the printer interface 4012. The

printer interface generates pixel clocks PCK-1 through PCK-4 as well as in the normal printing operation.

When the pulse-width dispersion is corrected, the Dispersion Correct command BC is at level "1" and consequently all selected pixel clocks SPCK-1 through SPCK-4 from the pixel clock selector 5001 are equal to the first pixel clock PCK-1 as illustrated in FIG. 68 (a).

The correction data D6 generated by the correction data generating block 5000 in response to the Dispersion Correct command BC is output to the beam synchronizer 4030 to stop the multi-level image data D2 from the RIP expansion unit 4009.

The beam synchronizer 4030 outputs multi-level image data D3 (correction data D6) in synchronism with the first pixel clock PCK-1 as illustrated in FIG. 68 (b). Similarly, PWM4303 through PWM4306 outputs D4-1 through D4-4 in synchronism with the first pixel clock PCK-1 as illustrated in FIG. 68 (c) through (f).

As explained above, the pulse-width dispersion can be corrected by D4-1 through D4-4 output from PWM4303 through PWM4306 in synchronism with any of the pixel clocks PCK-1 through PCK-4.

Although print data D4 is output also when the pulse-width dispersion is corrected, printing is not

done as the Print Request signal PREQ is not fed to the laser printer 4003.

As illustrated in FIG. 58 (c) through (f), print data D4-1 through D4-4 have different pulse widths pw1 through pw4. This operation and correction according to present invention will be explained referring to FIG. 70.

FIG. 70 is a characteristic graph representing the relationship of multi-level image data D3 fed to PWM4303 through PWM4306, print data output from PWM4303 through PWM4306 and sizes of dots in the main scanning direction which are printed on the recording sheet by LD light sources 4044 through 4047.

As the number of PWMs in the pulse-width modulator increases, the relationship between the multi-level image data D3 and the print data D4 changes as illustrated in FIG. 70.

For example, when monitor image data SD1 is entered as multi-level image data D3, the pulse-width modulation values (print data) D4-1 through D4-4 output from PWM4303 through PWM4306 have pulse-widths pw1 through pw4. As the result, print sizes are W1 through W4.

According to the present invention, the pulse width pw4 of the pulse-width modulation value D4-1

output from PWM4306 is set to a target modulation value (reference pulse-width) TPW and light-quantity correction data PC-1 through PC-4 are generated according to differences "pw4 - pw1," "pw4 - pw2," and "pw4 - pw3." In other words, the print dot size W4 can be set for any laser beam by generating the light-quantity correction data PC so that the differences "pw4 - pw1," "pw4 - pw2," and "pw4 - pw3" may be 0 (by equalizing the pulse widths pw1, pw2, pw3, and pw4).

Although FIG. 70 assumes that multi-level image data D3 is linearly proportional to print data D4, this correction method is also applicable when the relationship between multi-level image data D3 and print data D4 is curved.

The above pulse-width dispersion correction will be explained in detail referring to FIG. 68.

When a Dispersion Correct command BC is generated, the pulse-width modulator receives multi-level image data D3 (illustrated in FIG. 68 (b)) in synchronism with the pixel clock SPCK-1 (illustrated in FIG. 68 (a)) and outputs print data D4-1 through D4-4 (illustrated in FIG. 68 (c) through (f)) in synchronism with the pixel clock SPCK-1.

The target value setting block 4020 selects one of print data (pulse data) D4-1 through D4-4 output from



PWM4048 through PWM4051 in the pulse-width modulator 4010 as a reference value used for calculation of dispersions in the pulse-width modulation and outputs this as a target modulation value TPW (reference  
5 pulse-width modulation value) to the subtraction block 4021 and to the light-quantity correction data converting block 4400.

FIG. 68 uses the print data D4-4 (illustrated in FIG. 68 (g)) having the greatest pulse width among  
10 print data D4-1 through D4-4 as a target value TPW.

The user can select print data having any pulse width as a target value TPW.

The subtracting block 4021 takes a pulse-width difference between the target value TPW and each print  
15 data D4-1 through D4-4 and outputs the result (DPW-1 to DPW-4 (illustrated in FIG. 68 (h) to (k)) to the light-quantity correction data converter.

In this way, the magnitude of the results of subtraction, that is, the size of the pulse-width  
20 difference between the target value TPW and each print data D4-1 through D4-4 is converted into the magnitude of the light-quantity correction data, that is, the magnitude of the light-quantity correction time period.

The operation of PWM4303 for correcting print data  
25 D4-1 by this light-quantity correction data PC-1 will

be explained below in FIG. 69.

The reference clock SCK ((g) in FIG. 69) is obtained by dividing the pixel clock PCK-1 by 2. FIG.69 shows eight odd-numbered delay clocks (DCK-1, DCK-3, DCK-5, ...) among 16 delay clocks which the delay clock generator 4201 generates ((h) to (o) of FIG. 69).

The delay time measuring block 4202 measures delay time periods of delay clocks DCK by the input of a delay time measuring command signal MES periodically or non-periodically such as at the startup of the device or just before image formation. Namely, the delay time measuring block 4202 selects a delay clock DCK to get a delay time equivalent to time "t0" of one pixel at the rise (time T1) of reference clock 4215 as a sampling clock 4234.

In the example, the delay time measuring block 4202 detects a delay clock DCK-11 (t6) and a delay clock DCK-13 (t7) which change their signal states (from "1" to "0") just before or after time T1. With this, the delay time measuring block 4202 judges that the delay clock DCK-11 (t6) is a delay clock to get a delay time equivalent to "t0" and outputs "11" (in decimal) as a delay time measuring value 4208.

The delay clock selector 4203 selects a desired

number of delay clocks (among 16 delay clocks DCK generated) which are within the delay time measurement value DLT. This number of delay clocks is determined according to the maximum tones (resolution) of the input image information or half-tones required by output images.

The example illustrated in the drawing selects and outputs six delay clocks SDCK from the odd-numbered buffer gates among delay clocks DCK-1 through DCK-11 which are in the delay time measurement value DLT so that the differences of pulse widths of the generated pulses GPW may be approximately equal to each other (as illustrated in FIG. 69 (p) through (u)).

To select delay clocks SDCK, the user can select so that the ratio of pulse widths of the generated pulses GPW may be constant in addition to the above method of selection.

The pulse generator 4204 performs logical operations on the reference clock SCK and the six selected delay clocks SDCK and generates six pulse signals GPW-1 through GPW-6 ((p) to (u) in FIG. 69)).

The pulse selector 4205 receives multi-level (8-level) image data D3-1, selects one of the six generated pulse signals 4210, an all-white pulse signal (of all zeros) and an all-black pulse signal

(of all ones) and outputs it as print data APW which is modulated (pulse-width modulated) along the time base.

In FIG.69, as the multi-level image data D3-1 ((b) in FIG.69) is "2" (in decimal) during a time period (T0 to T1), the pulse selector 4205 outputs a generated pulse GPW-2 ((q) in FIG. 69). The signal becomes print data APW ((c) in FIG. 69). Similarly as the multi-level image data D3-1 ((b) in FIG. 69) is "5" (in decimal) during a time period (T1 to T2), the pulse selector 4205 outputs a generated pulse GPW-5 ((t) in FIG. 69). The signal becomes print data APW.

The pulse width adjusting block 5003 delays print data APW-1 ((c) in FIG. 69) by a time period set by the light-quantity correction data PC-1 and generates delayed print data DAPW ((e) in FIG. 69). The selector 4495 of FIG. 64 executes this function.

Accordingly, as the time differences "t11" and "t12" between the print data APW ((c) in FIG. 69) and the reference clock SCK are equivalent to the result of subtraction DPW-1 ((h) in FIG. 69), the generated print data D4-1 has the pulse width increased by "t11" and "t12" ((e) in FIG. 69) by this correction.

In this way, the pulse-width correction is performed in a multi-beam image recording device by

modulating pulse widths in synchronism of outputs of the PWM pulse generating block, obtaining their dispersion, and correcting pulse-widths according to this dispersion. This equalizes power energies of laser beams forming print dots and consequently enables high-quality image printing.

Further, as this method uses the pulse-width of one of pulse signals (print data) output from the PWMs as the reference pulse width, the user need not provide an extra unit to set a reference pulse-width.

Further, the user can cause a plurality of PWMs to perform pulse-width modulation in synchronism, that is, to restrict pulse-width modulation just by selecting a pixel clock.

Further, another embodiment of the present invention will be explained below referring to drawings.

FIG. 71 shows the functional block diagram of the printer system according to the present invention. The printer system consists of a printer controller 6001 for controlling the whole system, an operation block 6005 by which the user makes instructions, main storage block 6002 storing information which the printer controller 6001 requires, a printer engine 6003 having  $n$  laser beams and actually printing data,



beam-detection signals 6008 which the printer engine 6003 outputs when detecting laser beams (n beams), a signal position controller 6004 for controlling the positions of beam detection signals 6008, binary or multi-level image data 6006 (n data lines), an engine control signal 6007 which the controller 6001 uses to control the printer engine, beam detection signals 6009 controlled by the signal position controller 6004, control signals 6011 which the controller 6001 uses to control the laser beam detection position controller 6004, and user-set position control signal 6012 which is stored in the main storage 6002.

The main storage 6002 stores data of a test chart having basic areas in which a basic pattern 6101 is repeated by an arbitrary number of times in the main and subsidiary scanning directions. The basic pattern is characterized in that a pattern having "n x m" dots (where "n" and "m" are integers) in the subsidiary scanning direction and any number of dots in the main scanning line is repeated twice or more in succession, that their boundary is moved one dot leftward, rightward, and both in the main scanning direction, and that upper and lower beams on the boundary are made up by all possible combinations of beams.

FIG. 79 shows one example of such basic pattern

6101 used in a 2-laser image recording device.

The basic pattern 6101 repeats a 2 x 2 unit pattern (2 dots in the subsidiary scanning direction and 2 dots in the main scanning direction) five times in the subsidiary scanning direction with the unit pattern moved leftward or rightward (in the main scanning direction) by one dot for each subsidiary scanning.

A line 6105 in FIG. 79 is a beam detection signal A line drawn by image data A 6006-1 corresponding to a beam detection signal A 6008-1. Similarly, a line 6106 in FIG.79 is a beam detection signal B line drawn by image data B 6006-2 corresponding to a beam detection signal B 6008-2. FIG. 81 (2) shows a printout example of the basic pattern 6101 made by repeating the beam detection signal A 6008-1 and the beam detection signal B 6008-2 at preset intervals of tbd as illustrated in FIG.81 (1).

FIG. 82 shows a printout example of the basic pattern 6101 made by repeating beam detection signals A and B while the beam detection signal B 6008-2 is delayed by  $\Delta$  tbd (relative to the preset timing "tbd"). As illustrated in FIG. 82 (1), the image deviation 6102 is made by a delay ( $\Delta$  tbd/T) of a line drawn by the image data B 6006-2 due to a delay ( $\Delta$  tbd) by

which the rise position of the actual signal 6008-2 is behind the original rise position 6099 of the signal 6008-2.

5 This printout image 6108 is not symmetrical although the basic pattern is symmetrical about the vertical line. Although it is hard to estimate the deviation, the user can recognize it easily because the left side of the pattern looks smooth but the other side of the pattern looks jagged.

10 FIG. 83 (1) shows the waveforms of beam detection signals A 6008-1 and B 6008-2 in which the beam detection signal B 6008-2 rises earlier by  $\Delta$  tbd than the preset rise timing tbd. As illustrated in FIG. 83 (1), the image deviation 6102 is made by a time  
15 difference ( $\Delta$  tbd/T) of a line drawn by the image data B 6006-2 due to a time ( $\Delta$  tbd) by which the rise position 6100 of the actual signal 6008-2 is before the original rise position 6099 of the signal 6008-2.

20 This printout image 6109 is not symmetrical although the basic pattern is symmetrical about the vertical line. Although it is hard to estimate the deviation, the user can recognize it easily because the right side of the pattern looks smooth but the other side of the pattern looks jagged.

25 Judging from which side of the pattern is jagged,

the user can easily tell a direction to which the pattern is moved. For example, when the left side of the pattern is more jagged, it is assumed that the beam detection signal B 6008-2 rises earlier. To correct this, the beam detection signal B 6008-2 should be delayed. Contrarily, when the right side of the pattern is more jagged, it is assumed that the beam detection signal A 6008-1 rises earlier. To correct this, the beam detection signal A 6008-1 should be delayed.

As explained above, the deviation and the direction of deviation of beam detection signals 6008 can be known simply from printouts of basic patterns 6101.

FIG. 80 shows data of a test chart used by the present invention.

The test chart used by the present invention consists of a plurality of basic areas each of which contains 20 basic patterns 6101 in the main scanning direction. The number of basic patterns 6101 in the basic area need not be 20. The basic area can contain as many basic patterns as the basic area can contain. As said basic pattern 6101 occupies 10 dots in the subsidiary scanning direction, the basic area is made up by 16 lines including upper and lower margins and

the basic pattern 6101. Basic areas 6103 of the test chart are respectively given serial numbers called identifiers 6104 for identification. An identifier 6104 is placed before each basic area 6103.

5       As the basic area of this example is made up by a total of 16 lines, either the beam detection signal A 6008-1 or beam detection signal B 6008-2 should be delayed in sequence for every 16 lines to test line deviations. Let's assume that the minimum delay is  
10       "d." This example delays the beam detection signals as explained below.

For the first basic area (16 lines) 6110, neither beam detection signal A 6008-1 nor beam detection signal B 6008-2 is delayed. For the second basic area  
15       (16 lines) 6111, the beam detection signal A 6008-1 is delayed by "d" but the beam detection signal B 6008-2 is not delayed. For the third basic area 6112, the beam detection signal A 6008-1 is delayed by "2d" but the beam detection signal B 6008-2 is not delayed.

20       In this way, for each of the succeeding basic areas (6113, 6114, ...), the beam detection signal A 6008-1 is delayed by "n x d" (wherein "n" is 3, 4, 5, ...) but the beam detection signal B 6008-2 is not delayed. This is repeated until the beam detection  
25       signal A 6008-1 is delayed fully. Then repeat the



above steps reversing beam detection signals. Namely, the beam detection signal B 6008-2 is delayed by " $n \times d$ " but the beam detection signal A 6008-1 is not delayed

5        This example assumes that the cycle of the pixel clock is 32 ns and that the permissible scanning start position error is 1/6 dot. In this case, 1/6 dot is equivalent to about 5.3 ns. Therefore, the minimum delay " $d$ " must be fully smaller than 5.3 ns. This  
10       example uses " $d = 2$  ns" and deviates the lines by the cycle ( $T$ ) of one pixel clock under this condition. As  $T / d$  is 16, this example provides 16 different positions for one beam detection signal.

15       Therefore, this example has 16 cases in which the beam detection signal A 6008-1 is in advance of the beam detection signal B 6008-2 and other 16 cases in which the beam detection signal B 6008-2 is in advance of the beam detection signal A 6008-1. This is the reason why the test chart has 32 basic areas.

20       In other words, basic areas of identifiers (6104) 1 to 16 are for cases in which the beam detection signal A 6008-1 is in advance of the beam detection signal B 6008-2. For each of these cases, the beam detection signal A 6008-1 is delayed by a multiple of  
25       2 ns with the beam detection signal B 6008-2 left

unchanged (until the beam detection signal A 6008-1 is delayed by the cycle of one pixel clock).

Similarly, basic areas of identifiers (6104) 17 to 32 are for cases in which the beam detection signal B 6008-2 is in advance of the beam detection signal A 6008-1. For each of these cases, the beam detection signal B 6008-2 is delayed by a multiple of 2 ns with the beam detection signal A 6008-1 left unchanged (until the beam detection signal B 6008-2 is delayed by the cycle of one pixel clock).

The user can always find an optimum case in which the amount of positional deviation is 2ns or less in the above 32 cases.

The circuit configuration and the operation of the laser beam detection position controller 6004 are explained below referring to FIG. 72.

The delay time controller A 6034 sends a position determining signal A 6017 to the beam detection signal delay circuit A 6030 according to the position controller control signal 6011 and the user-set position control signal 6012. The beam detection signal delay circuit A 6030 delays one of the beam detection signals (A 6008-1 in this example) by a preset time period according to the entered position determining signal A 6017 and outputs a controlled

laser beam detection signal A 6009-1.

Similarly, the delay time controller B 6068 sends a position determining signal B 6026 to the beam detection signal delay circuit B 6031 according to the position controller control signal 6011 and the user-set position control signal 6012.

The beam detection signal delay circuit B 6031 delays the other beam detection signal (B 6008-2 in this example) by a preset time period according to the entered position determining signal B 6026 and outputs a controlled laser beam detection signal B 6009-2.

Basically, the circuits A and B in the laser beam detection position controller 6004 are functionally the same. Accordingly only circuits A in the controller 6004 are explained as representatives.

Referring to FIG.73 is explained the delay time controller A 6034.

In FIG. 73, the delay time controller A 6034 consists of a Variable Position signal generator A 6035, a Fixed Position signal generator A 6036, and a position signal selector A 6050.

The operation of these circuits is explained below.

A signal 6011-1 is one of the Position Controller Control signal 6011 and a binary Position Test On signal which is "1" in the Position Test mode. A

signal 6011-2 is a binary signal indicating a print area in the subsidiary scanning direction.

The Variable Position signal generator A 6035 generates a Variable Position signal A 6015 whose rise position is changed at a preset timing and outputs it to the position signal selector A 6050. The Fixed Position signal generator A 6036 generates a Fixed Position signal A 6016 in response to a user-set position control signal 6012.

The position signal selector A 6050 outputs the Fixed Position signal A 6016 as a position determining signal A 6017 when the Position Test On signal 6011-1 is "0" (Normal Printing) or the Variable Position signal A 6015 as a position determining signal A 6017 when the Position Test On signal 6011-1 is "1" (Positional Test Printing).

FIG. 74 shows the circuit diagram of said Variable Position signal generator A 6035.

The Variable Position signal generator A 6035 consists of a basic area counter A 6014 which is an 8-bit binary counter, the higher 5-bit output 6013 of the basic area counter, inverters 6037 through 6040, and AND gates 6041 through 6044.

As this embodiment uses two laser beams and a test pattern whose basic area consists of 16 lines, the

delay time is changed when one beam scans 8 lines (assuming that one basic area is scanned). Using higher 5 bits of the eight output bits of the basic area counter A 6014, the output 6013 of the basic area counter A is incremented by one each time eight beam detection signals A 6008-1 are counted.

The Variable Position signals A 6015-1 through 6015-4 are incremented in sequence while the output 6013 of the basic area counter A 6014 is 0 to 15 (for basic areas of identifiers 1 through 16) but they remain 0 while the output 6013 of the basic area counter A 6014 is 16 to 31 (for basic areas of identifiers 17 through 32).

The Variable Position signal generator B in the delay time controller B 6068 is the same as the Variable Position signal generator A but the Variable Position signal generator B does not have any inverter 6037 through 6040.

FIG. 75 shows a circuit example of the Fixed Position signal generator A 6036.

In FIG. 75, the User-Set Position Control signal 6012 is a 5-bit binary signal having 6012-1 as the most significant bit and 6012-5 as the least significant bit which can represent a decimal value ranging 0 to 31. The Fixed Position signal generator A



6036 consists of an inverter 6045 and AND gates 6046 through 6049.

5 The Fixed Position signal generator A 6036 outputs a Fixed Position signal A 6016 in response of a User-Set Position Control signal 6012. The Fixed Position signal A 6016-1 through 6016-4 has the same value as the User-Set Position Control signal 6012 when the User-Set Position Control signal 6012 has a decimal value in the range of 0 to 15 or 0 when the User-Set  
10 Position Control signal 6012 has a decimal value in the range of 16 to 31.

FIG. 76 shows a circuit example of a position signal selector A 6050 of FIG. 73.

15 The position signal selector A 6050 consists of an inverter 6051 and selectors 6069 through 6072 for selecting one of two signals. The operation of the position signal selector A 6050 is explained below.

The position signal selector A 6050 outputs the Variable Position signal A 6015-1 through 6015-4 as a  
20 position determining signal A 6017-1 through 6017-4 when the Position Test On signal 6011-1 is "1" (Positional Test Printing) or the Fixed Position signal A 6016-1 through 6016-4 as a position determining signal A 6017-1 through 6017-4 when the  
25 Position Test On signal 6011-1 is "0" (Normal

Printing).

FIG. 77 shows a circuit example of a beam detection signal delay circuit A 6030 of FIG.72.

The beam detection signal delay circuit A 6030 consists of delay elements 6052 through 6066 which delay an entered signal by a preset time period and a selector 6067 which selects one of 16 signals. This example has sixteen 2-ns delay elements because the pixel clock cycle T is divided by "d = 2 ns."

The beam detection signal delay circuit A 6030 delays the beam detection signals A 6008-1 in sequence by the delay elements 6052 through 6066 and generates delayed beam detection signals A 6019 (6019-1 through 6019-16) having different positions.

The beam detection signal delay circuit A 6030 selects one of the delayed beam detection signals A 6019-1 through 6019-16 according to the position determining signal A 6017 (6017-1 through 6017-4) and outputs it as a controlled beam detection signal A 6009-1.

The waveforms of the operation of the delay time controller A 6034 in the Position Test mode is illustrated in FIG.78.

Upon receiving a command from the operation block 6005, the controller 6001 sets the Position Test mode

(to perform a position test on the whole printer system) and sends an instruction to the printer engine 6003 to print out test chart data. Simultaneously, the Position Test On signal 6011-1 goes high ("1"). A  
5 preset time later, the Subsidiary Scanning Direction Print Area signal 6011-2 goes high ("1").

At the rise of the Subsidiary Scanning Direction Print Area signal 6011-2, the basic area counter A 6014 has a count of 31 (in decimal) and starts to  
10 count the beam detection signal A 6008-1 from 00. In this example, as each basic area 6103 is made up by 16 lines and two laser beams are used, the output 6013 of the basic area counter A 6014 is incremented by one for every eight beam detection signals A 6008-1. The  
15 basic area counter A 6014 keep on counting until the counter is cleared by the Subsidiary Scanning Direction Print Area signal 6011-2 of "0."

The Variable Position signal A 6015 is counted up in sequence while the output 6013 of the basic area  
20 counter A 6014 is 0 to 15 and the controlled beam detection signal A 6009-1 is delayed (in relation to the beam detection signal A 6008-1) for each basic area 6103.

When the output 6013 of the basic area counter A  
25 6014 is 16 to 31 (for basic areas of identifiers

(6104) 17 to 32), the Variable Position signal A 6015 remains "0" and the beam detection signal A 6008-1 is output as the controlled beam detection signal A 6009-1.

5        FIG. 84 shows an example of a test chart which is actually printed by the present invention.

As explained above, the test chart data is output for each basic area 6103, changing the positions of the beam detection signals 6008. The user should  
10       select an optimum basic area in the printed test chart and enter its identifier 6104 as a user-set position control signal 6012 from the operation block 6005. This is stored in the main storage block.

The part which stores the positional information  
15       in the main storage block is a storage unit such as a floppy disk, hard disk, and the like which can keep on holding the information after the system is powered off. The positional information is kept in the storage unit until a new User-Set Position Control signal 6012  
20       is set by another positional test.

When a means which can retain a setting status such as a DIP switch is used as the input of the User-Set Position Control signal 6012 on the operation block 6005, the status of the User-Set Position  
25       Control signal 6012 is held until the user changes it

and the positional information need not be stored in the main storage block 6002.

It is possible to always keep and use the beam detection signals 6008 in good alignment by storing  
5 positional information of the well-aligned laser beams after the positional test in a storing means of the main storage block 6002 of the controller 6001 which can retain the information even after the system is powered off and by building up so that the positional  
10 information may be automatically loaded when the system is powered on again.

Even when the beam detection signals 6008 greatly deviate by an external factor (such as a great impact) or a secular change, the user can quickly correct the  
15 deviation by performing a positional test and setting an optimum position of the beam detection signals 6008.

It is also possible to prevent deterioration of images due to increasing deviation of beam detection signals 6008 by building the system so that the  
20 positional test may be automatically performed each time the system is powered on.

Said embodiment is basically applicable to image recording devices of three or more laser beams.

However, the beam position correcting steps for  
25 image recording devices of three or more laser beams



are much complicated. For example, take the following steps to correct beam positions in the 3-beam image recording device.

FIG. 85 shows the system configuration of a 3-beam printer system according to the present invention. In addition to the system configuration of the aforesaid 2-beam image recording device, said printer system in FIG.85 has a beam detection signal C (6008-3), binary or multi-level image data C (6006-3) corresponding to the beam detection signal C (6008-3), and a controlled beam detection signal C (6009-3) into which the positional controller 6004 controls the beam detection signal C (6008-3).

The main storage 6002 stores data of a test chart having basic areas in which a basic pattern (3 dots in the subsidiary scanning direction and 2 dots in the main scanning direction) is repeated four times in an adjoining manner in the subsidiary scanning direction with the basic pattern deviated by one dot left, right, and both in the main scanning direction each time the basic pattern is formed. The upper and lower beams on the boundary are made up by all possible combinations of beams.

The basic pattern is repeated ten times in the main scanning direction. The number of basic patterns

in the basic area need not be 10. The basic area can contain as many basic patterns as the basic area can contain. Further the basic pattern is repeated once in the subsidiary scanning direction. The test chart  
5 contains 32 said basic areas.

FIG. 86 shows a block diagram of the laser beam detection position controller 6004 in a 3-beam image recording system.

The laser beam detection position controller 6004  
10 consists of a beam detection signal delay circuit A (6030) which delays a beam detection signal A (6008-1) for a preset time period, a beam detection signal delay circuit B (6031) which delays a beam detection signal B (6008-2) for a preset time period, a beam  
15 detection signal delay circuit C (6130) which delays a beam detection signal C (6008-3) for a preset time period, and a micro computer 6128 which controls a delay time of each of said beam detection signal delay circuits.

20 The micro computer 6128 outputs the controlled beam detection signals A (6009-1), B (6009-2), and C (6009-3) according to the Position Control Block Control signal (6011) and the User-Set Position Control signal (6012).

25 FIG. 87 shows a basic pattern used by this

embodiment for the positional test.

The basic pattern 6121 is made up by repeating a pattern unit (3 dots in the subsidiary scanning direction and 2 dots in the main scanning direction) four times in an adjoining manner in the subsidiary scanning direction with the basic pattern deviated by one dot left, right, and both in the main scanning direction each time the basic pattern is formed.

The patterns made by upper and lower adjoining beams (beams 1 and 2, 2 and 3, and 3 and 1) represents all possible combination of patterns.

These basic patterns are separated into three 6121-1 through 6121-3 according to the combinations of adjoining upper and lower beams. Identifiers (6122) are given to the separated basic patterns for identification.

In FIG. 87, the line 6105 is a line drawn by image data A (6006-1) corresponding to the beam detection signal A (6008-1). The line 6106 is a line drawn by image data B (6006-2) corresponding to the beam detection signal B (6008-2). Similarly, the line 6123 is a line drawn by image data C (6006-3) corresponding to the beam detection signal C (6008-3).

Let's assume waveforms of beam detection signals A, B, and C as illustrated in FIG.88 in which the beam

detection signal B (6008-2) rises (at 6100) earlier by  $\Delta tbd1$  than the preset rise position 6099, the beam detection signal C (6008-3) rises (at 6126) later by  $\Delta tbd2$  than the preset rise position 6125, and  $\Delta tbd1$  is greater than  $\Delta tbd2$ .

Taking the beam detection signal A (6008-1) as a reference signal, the positional difference between beam detection signals A (6008-1) and B (6008-2) is  $\Delta tbd1$  and the positional difference between beam detection signals A (6008-1) and C (6008-3) is  $\Delta tbd2$ . The positional difference between beam detection signals B (6008-2) and C (6008-3) is  $\Delta tbd2$  minus  $\Delta tbd1$ .

6127 in FIG. 88 shows the result of printout of basic pattern 6121 under the aforesaid conditions. Select a basic pattern which is furthest from bilateral symmetry among the printed basic patterns 6127-1 through 6127-3 and enter its identifier 6122 from the operation block 6005. The printer controller 6001 sends its information in a form of a position controller control signal 6011 to the micro computer 6128 in the position control block 6004.

Further, if there is no laser beam detection signal position control block 6004, the sub-basic pattern 6127-3 corresponding to the sub-identifier

6122 is apparently furthest from bilateral symmetry.  
Its right side is smooth but its left side is  
extremely jagged. The user enters "C" from the  
operation block 6005. With this, the micro computer  
5 6128 judges that the difference between the beam  
detection signals B (6008-2) and C (6008-3) is the  
greatest.

To eliminate this difference between the beam  
detection signals B (6008-2) and C (6008-3), the micro  
10 computer 6128 changes the positions of the beam  
detection signals B (6008-2) and C (6008-3) in  
sequence while the beam detection signal A (6008-1) is  
left unchanged.

Then print the test chart data (in the same manner  
15 as in the 2-beam image recording device) with the  
positions of the beam detection signals B (6008-2) and  
C (6008-3) changes in sequence.

Enter the identifier 6129 of the optimum basic  
pattern from the operation block 6005. With this, the  
20 micro computer 6128 corrects the difference between  
the beam detection signals B (6008-2) and C (6008-3).

If the sub-identifier (6122) A is entered from the  
operation block 6005, the micro computer 6128 judges  
that the difference between the beam detection signals  
25 A (6008-1) and C (6008-3) is the greatest and makes



the position of the beam detection signal B (6008-2) fixed.

If the sub-identifier (6122) B is entered from the operation block 6005, the micro computer 6128 judges  
5 that the difference between the beam detection signals A (6008-1) and B (6008-2) is the greatest and makes the position of the beam detection signal C (6008-3) fixed.

With these operations, the difference between the  
10 beam detection signals B (6008-2) and C (6008-3) is eliminated. Next set the Position Test mode to eliminate the difference between the beam detection signals A (6008-1) and B (6008-2) with the positional relationship between beam detection signals B (6008-2)  
15 and C (6008-3) fixed. (When the position of the beam detection signal B (6008-2) is changed, the position of the beam detection signal C (6008-3) must be changed by the same amount.)

The user selects a basic pattern having the best  
20 bilateral symmetry in the printed test chart and enters its identifier (6132) from the operation block 6005. The micro computer 6128 corrects the positional relationship between the beam detection signals A (6008-1) and B (6008-2). With this, the correction of  
25 the positional relationship of the beam detection

signals A (6008-1), B (6008-2) and C (6008-3) is completed.

The above-explained procedure is easily applicable to image recording devices having n laser beams even  
5 when the device uses more laser beams and their positional relationship is more complicated.

FIG.89 shows a system configuration of an image recording devices having n laser beams.

The image signal position control block 6145  
10 receives image signals 6006 from the controller 6001, controls their positional relationship, and outputs the controlled image signal 6147.

The operation and the effect of this example are the same as those of the above-explained examples but  
15 the beam detection signals 6008 and image signals 6004 are changed.

The user can perform the positional test completely independently from the controller 6002 by providing a storage unit 6151 and an image  
20 processing/scanning unit in the image signal position control block 6145 and moving the storage unit (which stores test chart data and positional information) from controller 6001 into the storage unit 6151.

This means that application of the present  
25 invention to the conventional printer system does not

require any modification of the controller 6001.

Further, the conventional printer systems respectively have an image processor 6152. FIG. 91 shows the configuration of a conventional printer system having an image processor 6152.

The image processor 6152 usually receives image signals 6006 from the controller 6001, performs disclosed processing such as resolution enhancement, gray-scale enhancement or the like on the signals, and outputs the processed image signals 6148.

As such an image processor 6152 already possesses image signals 6006 and engine control signals 6007, it is very easy to add a function of the image signal position controller 6145 to the image processor 6152. Therefore, the user can get images without positional deviations. Also in this case, it is apparent that the controller 6001 of a conventional printer system to which the present invention does not require any modification only if the image processor having the function of the image signal position controller 6145 contains a storage unit 6151 and an image processor operation unit 6150.

(Industrial Availability)

As explained above, the image recording device according to the present invention can record high-

quality high-resolution images and is available as a multi-beam image recording device having a plurality of light sources (laser beams).